



図 2 (A)

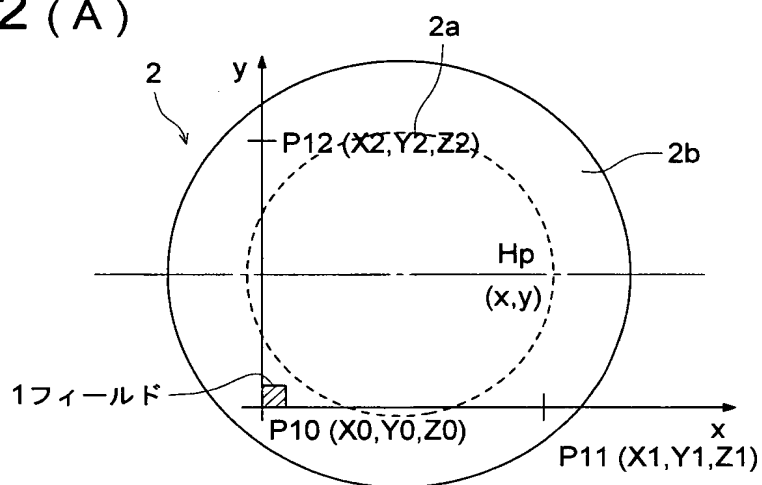


図 2 (B)

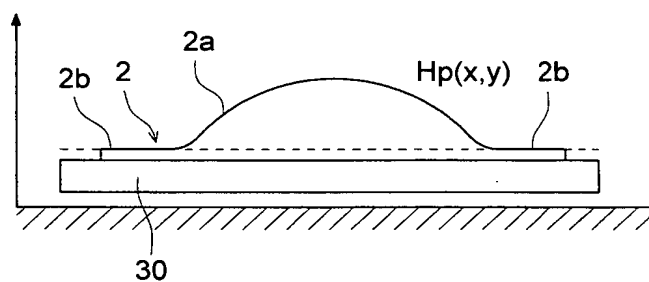


図 2 (C)

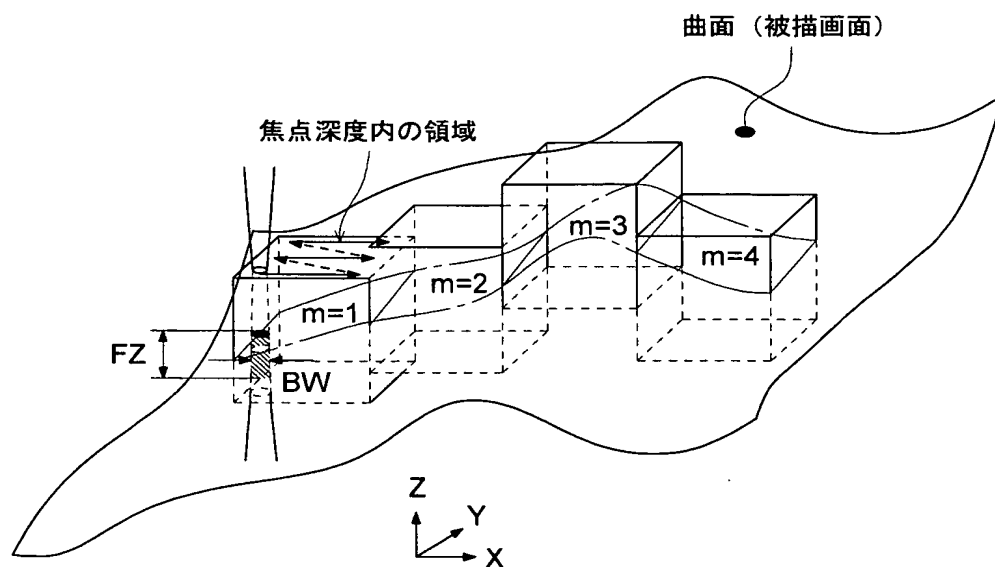


図 3

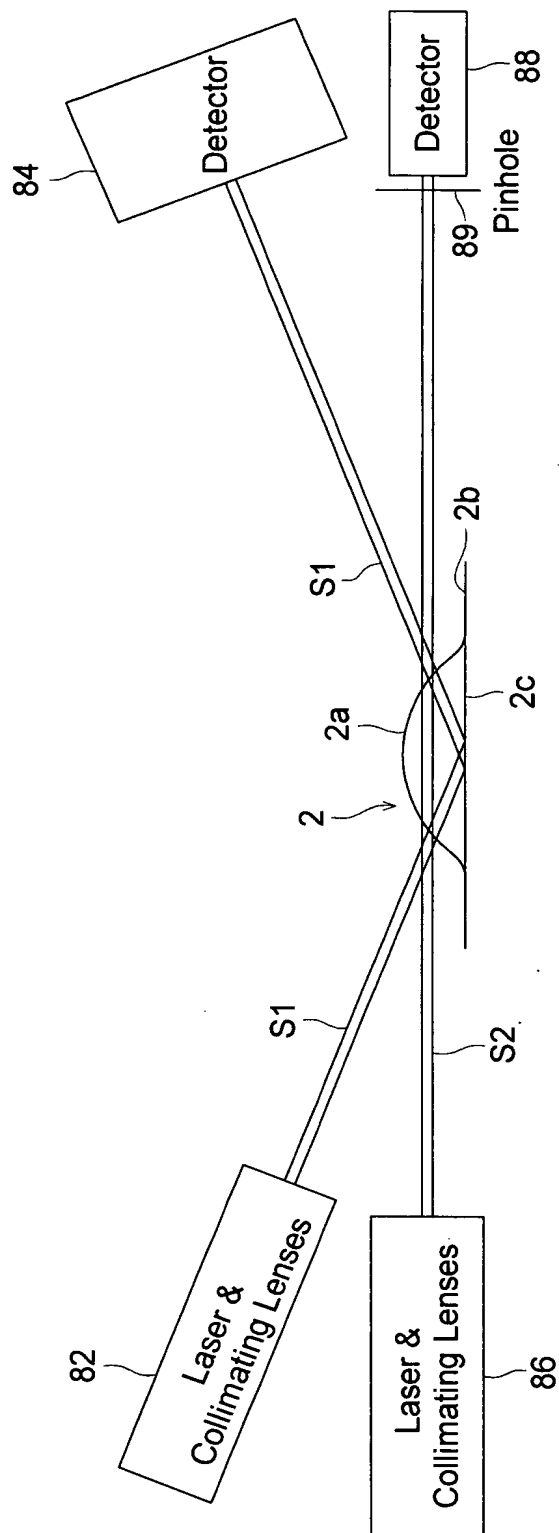


図 4

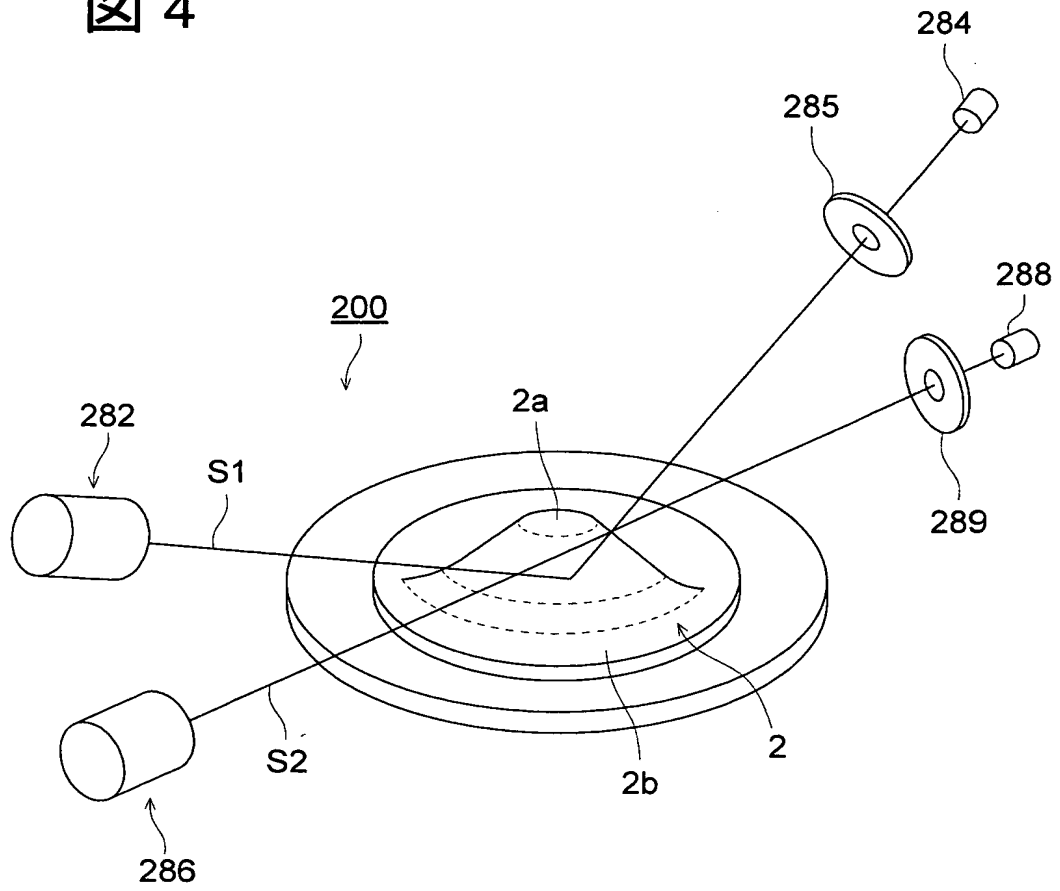


図 5 (A)

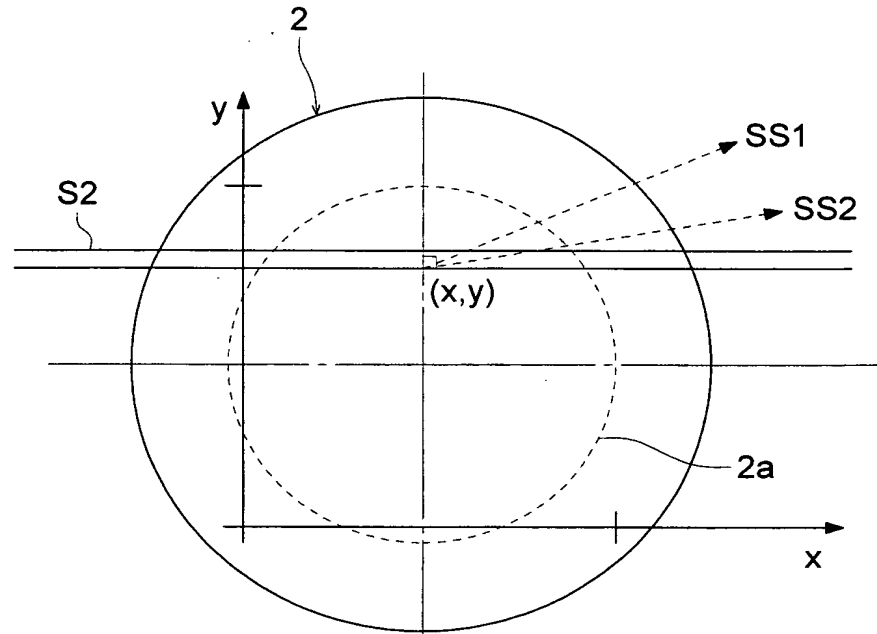


図 5 (B)

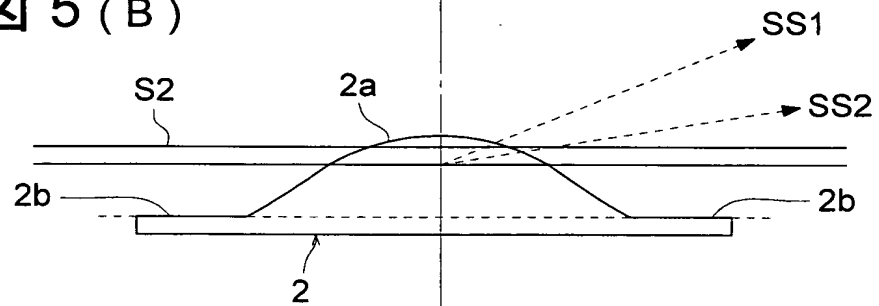


図 5 (C)

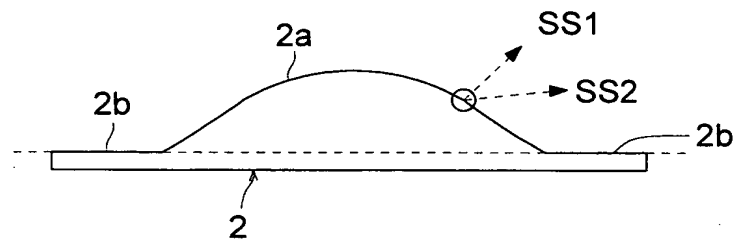


図 6

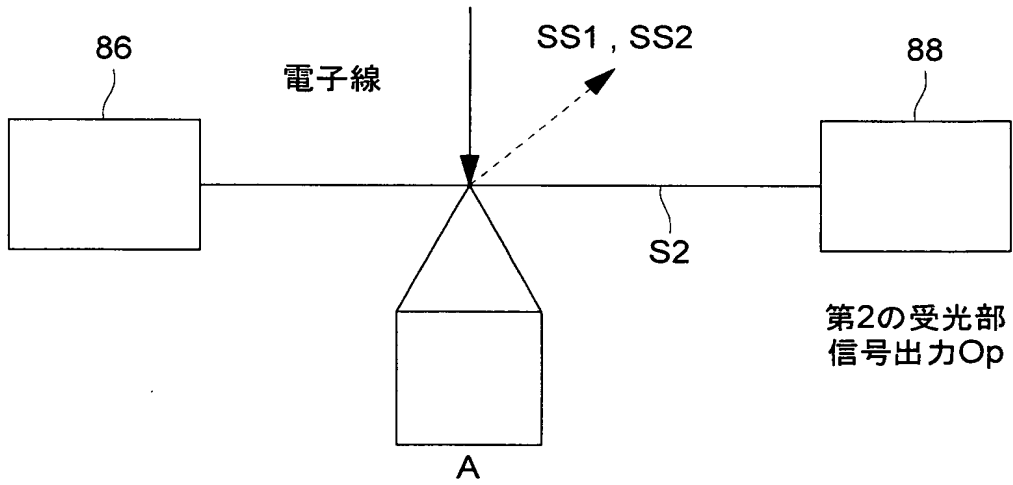


図 7

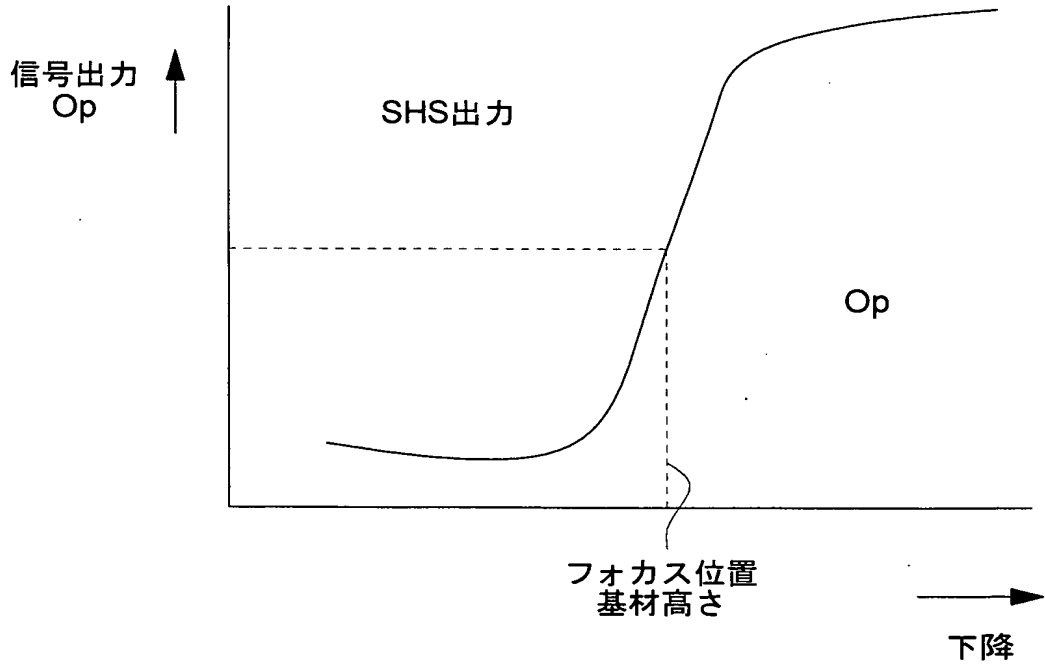


図 8

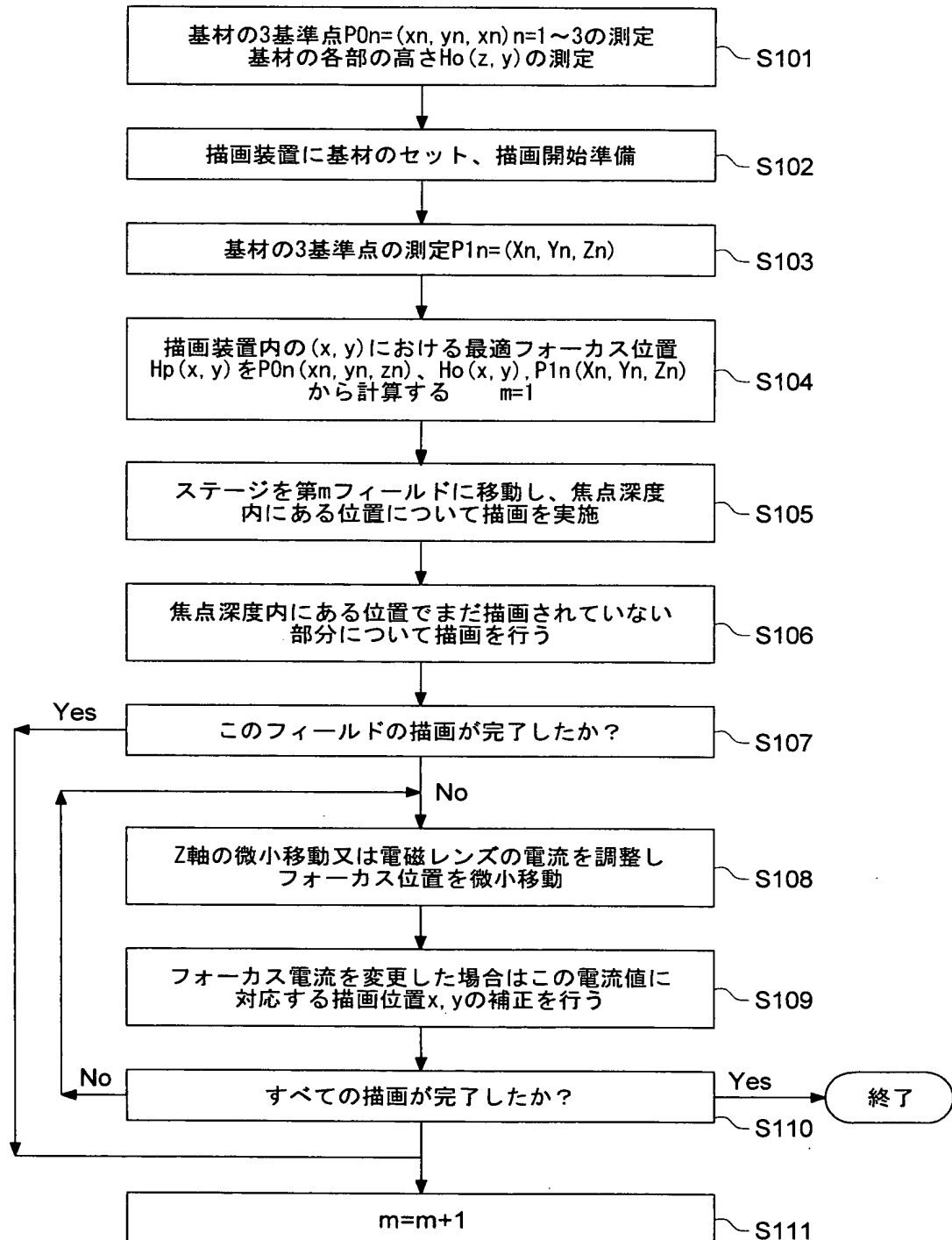
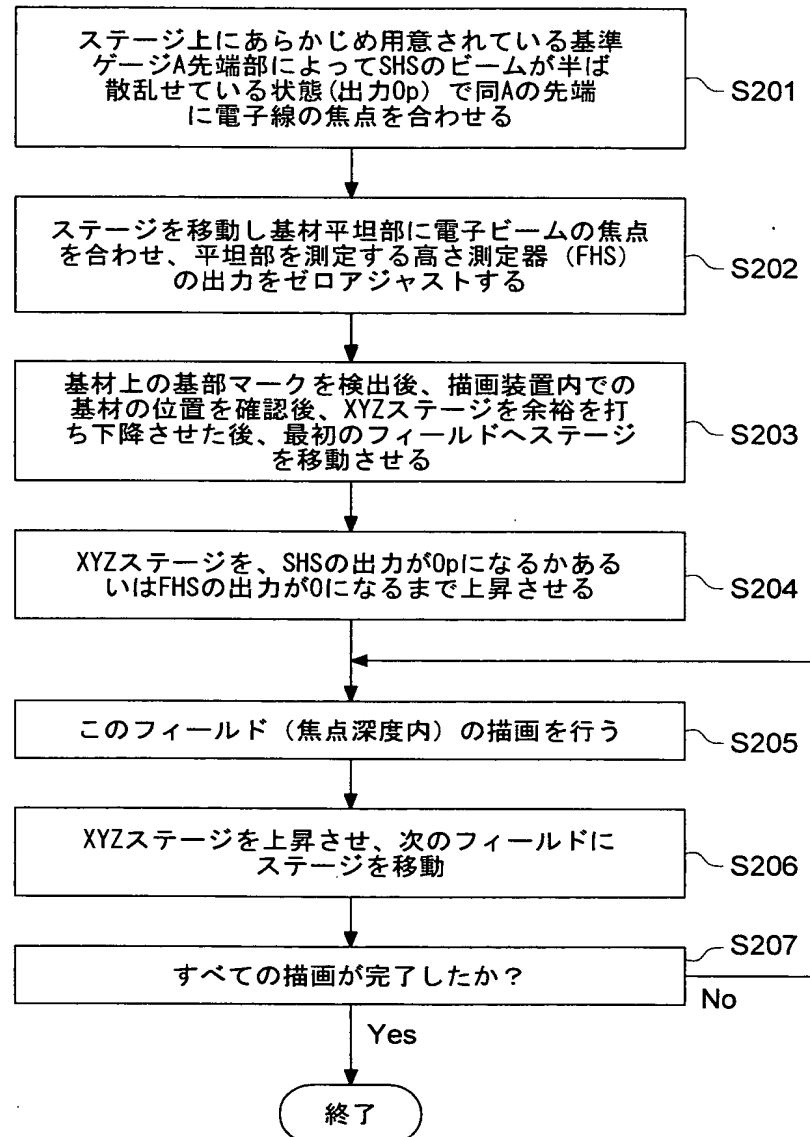


図 9



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図 10

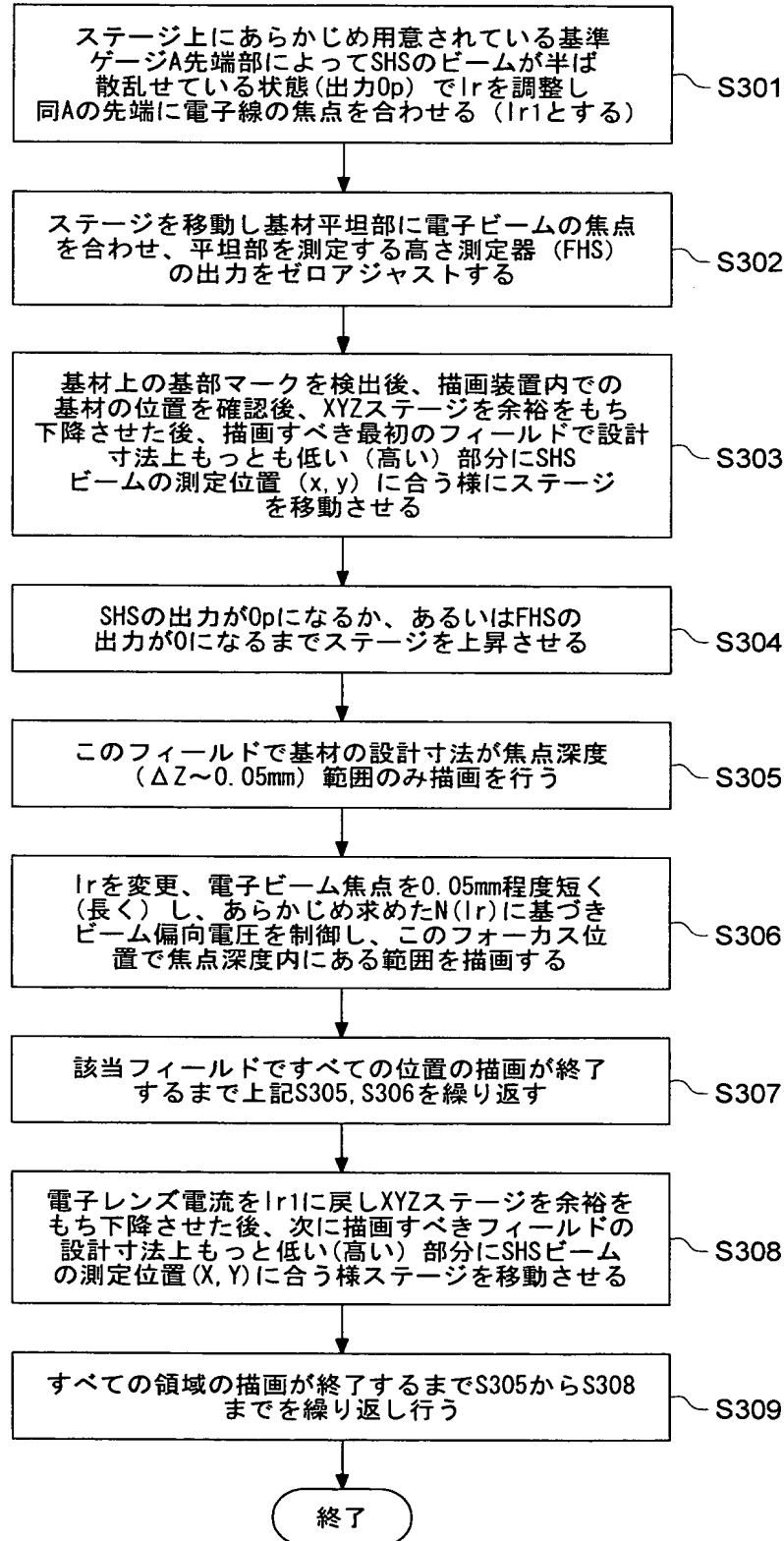


図 11

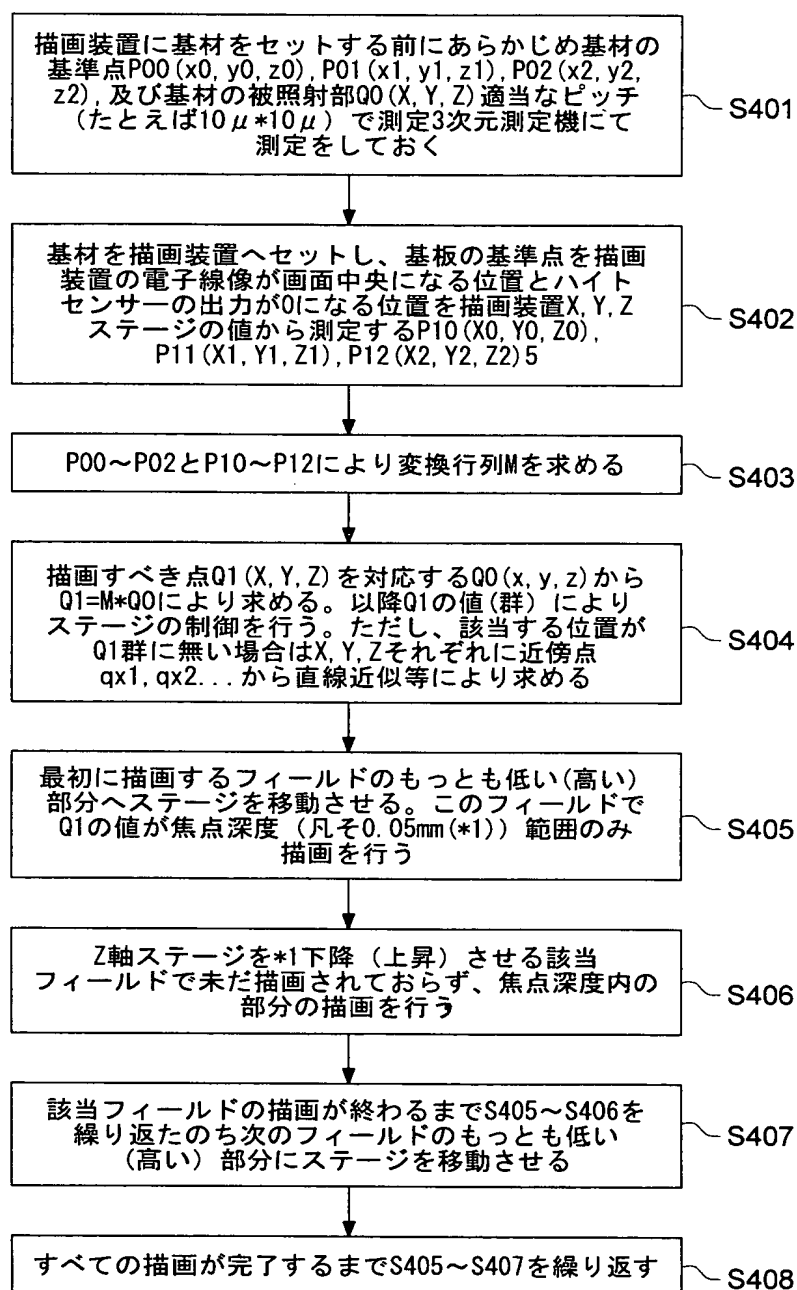


図 12

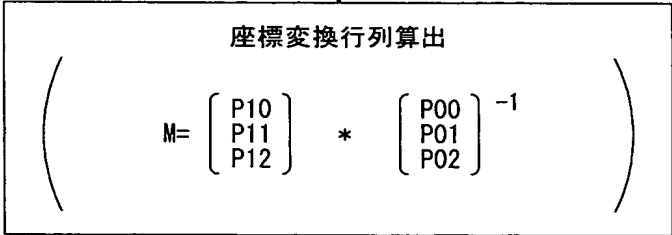


図 13 (A)

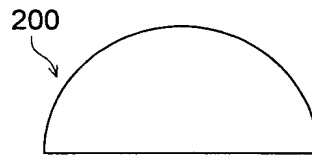


図 13 (B)

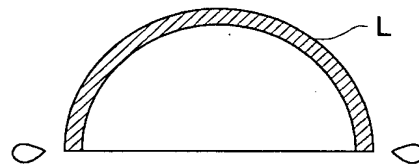


図 13 (C)

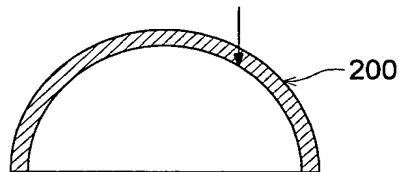


図 13 (D)

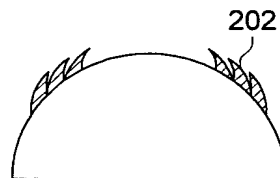


図 13 (E)

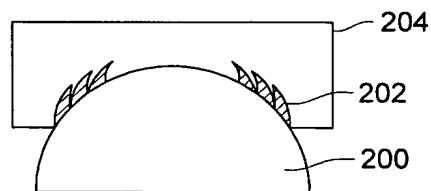


図 13 (F)



図 14

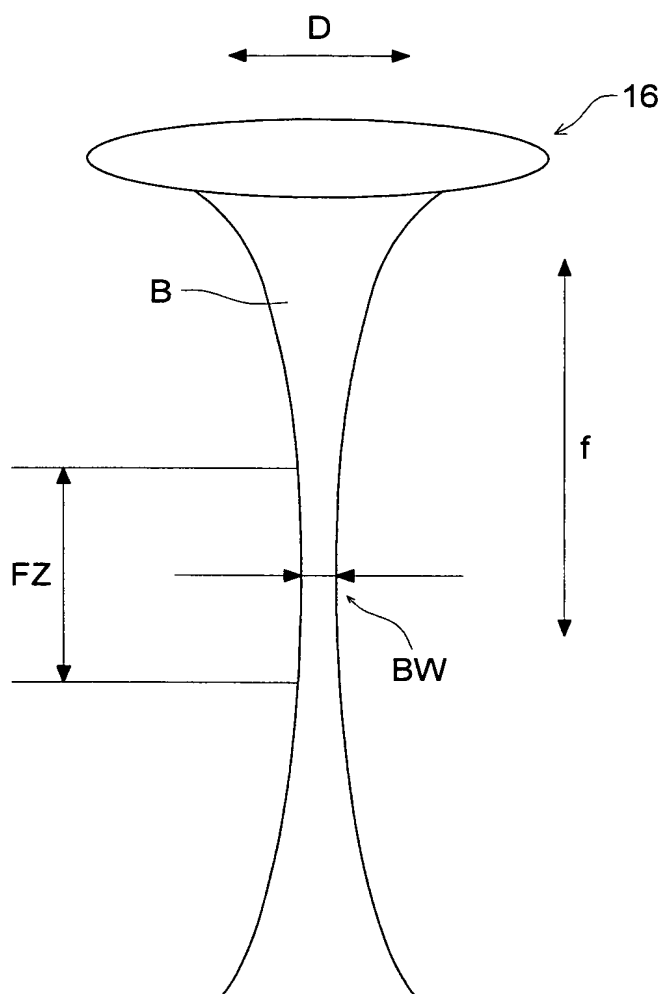
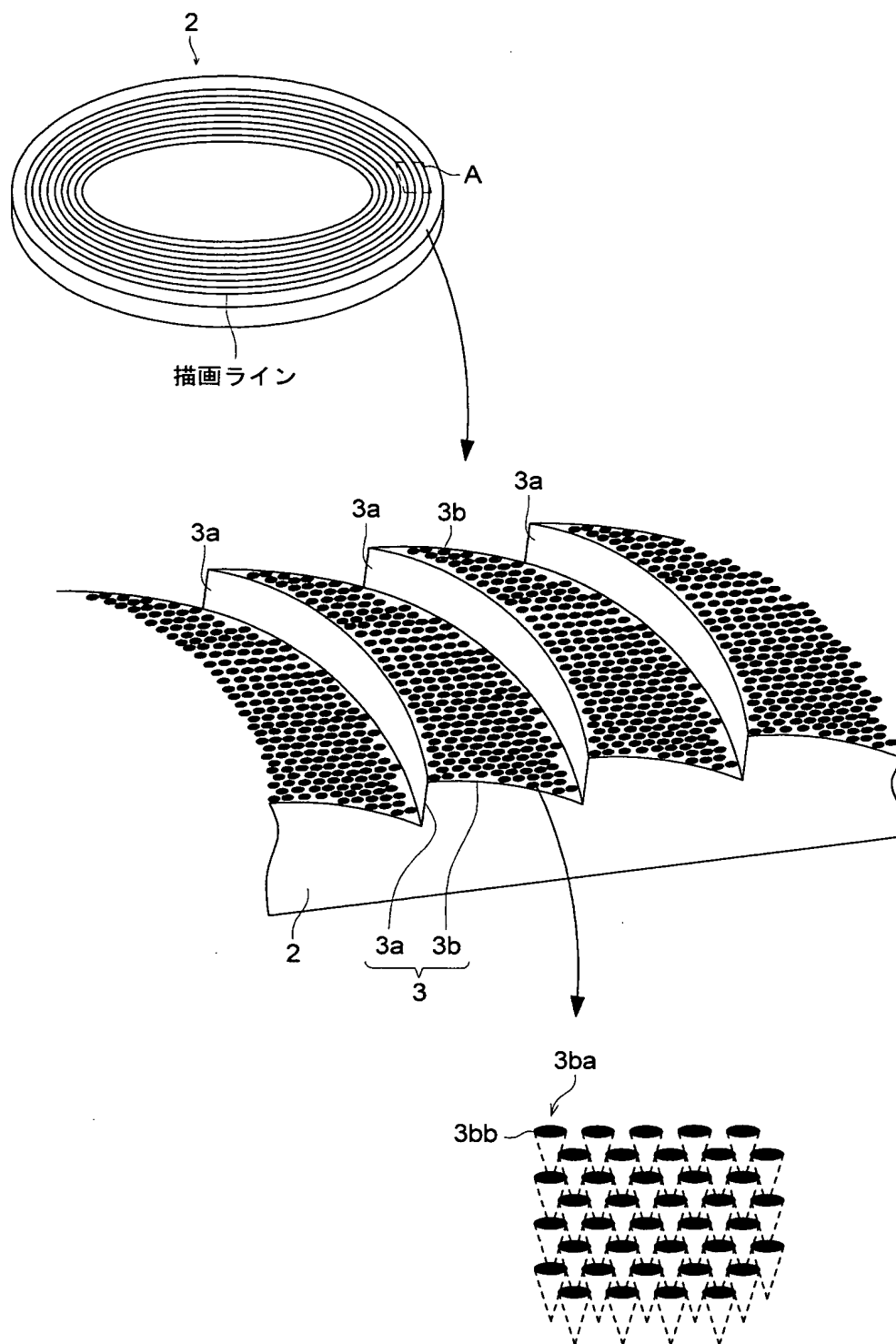


図 15



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Diagram illustrating a sawtooth-shaped structure 3. The structure consists of a series of peaks and valleys. The top surface of the peaks is labeled 3a, the sloped surface is labeled 3b, and the vertical surface is labeled 3c. The sloped surface 3b is shown with a series of small triangles, indicating a sawtooth profile. A dashed line 2a is shown below the structure, representing a reference surface. The horizontal distance between two vertical dashed lines is labeled L1, and the vertical distance between the dashed line 2a and the base of the structure is labeled L2. A curved arrow R indicates a rotation or movement of the structure.

図 17

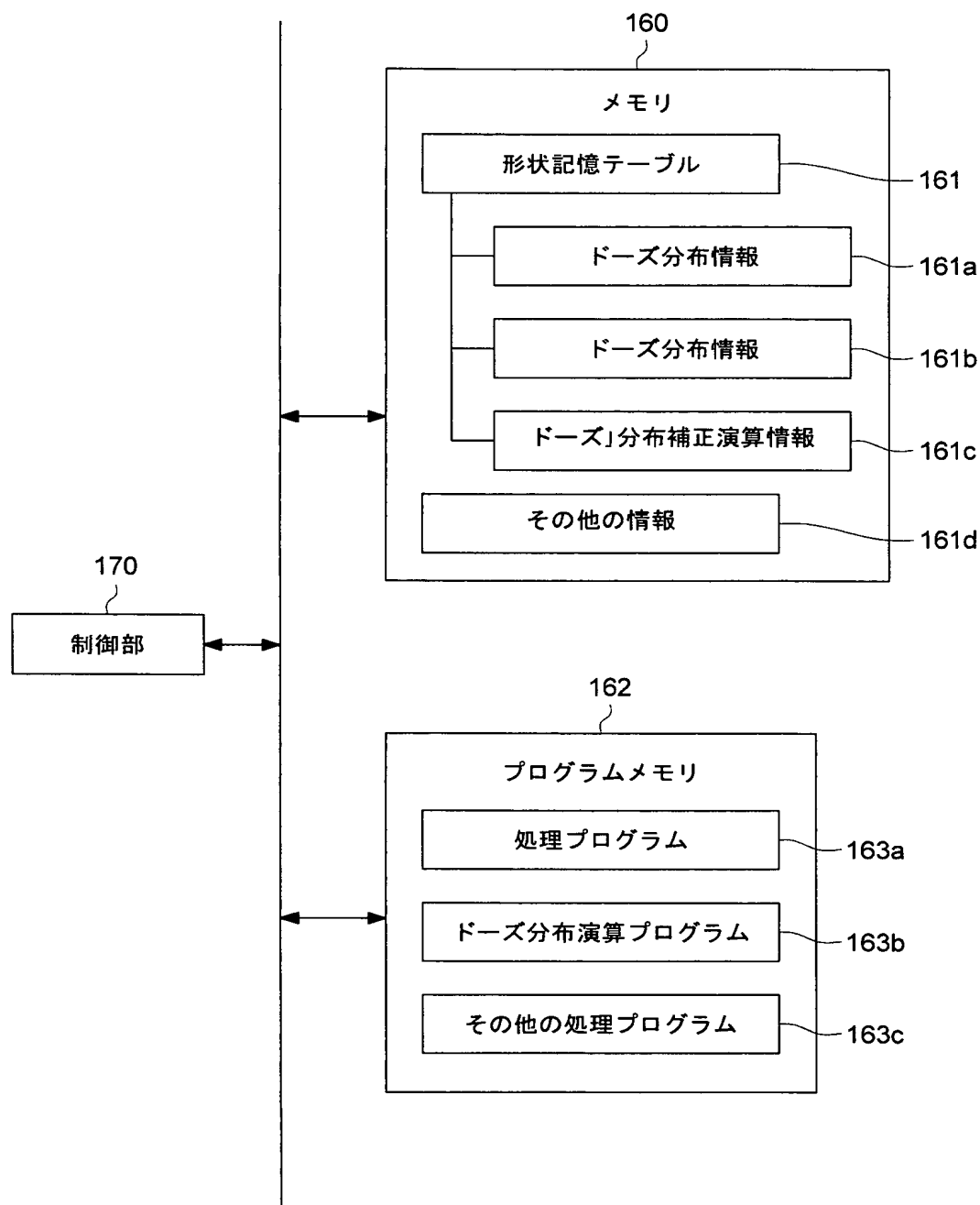


図 18

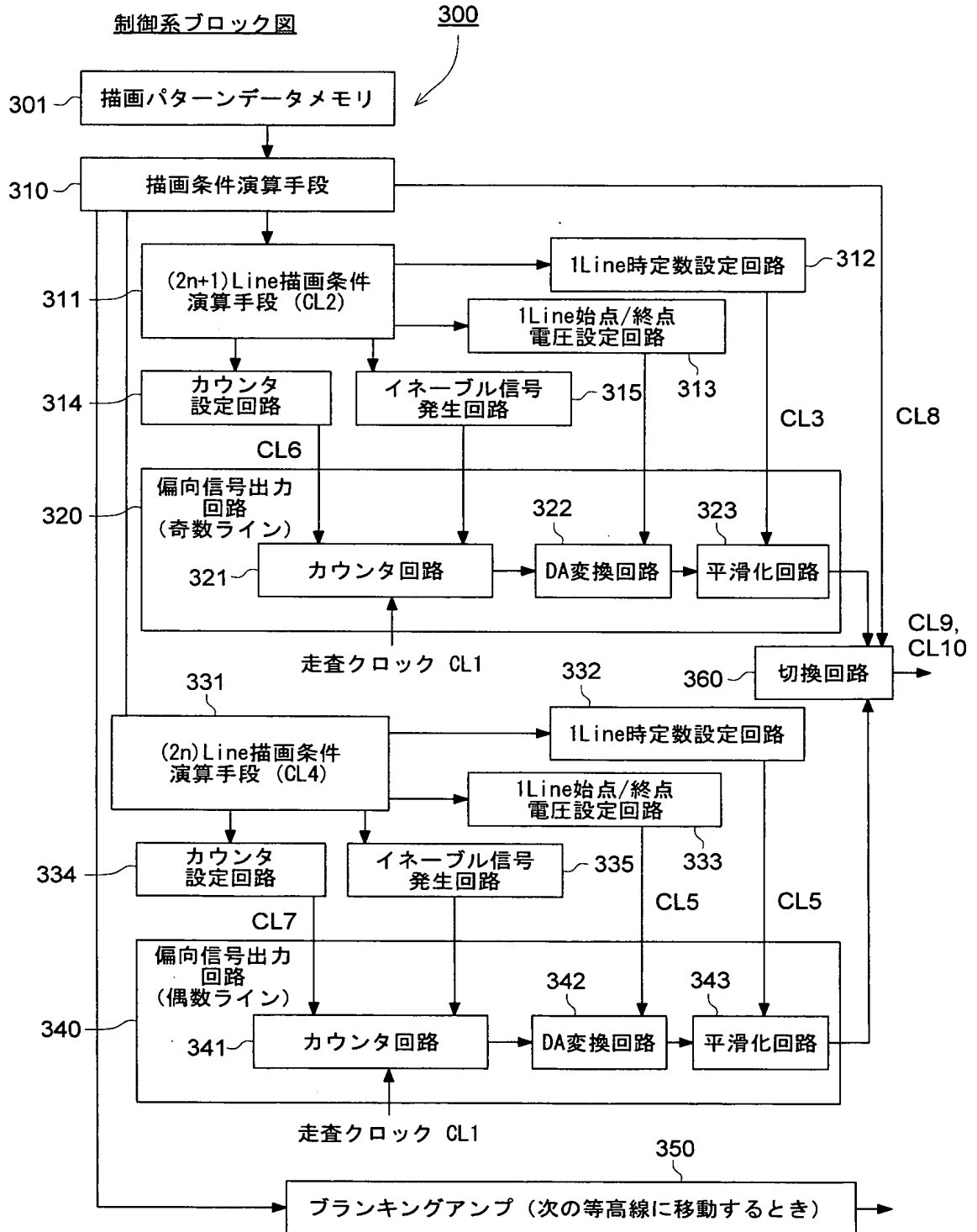


図 19

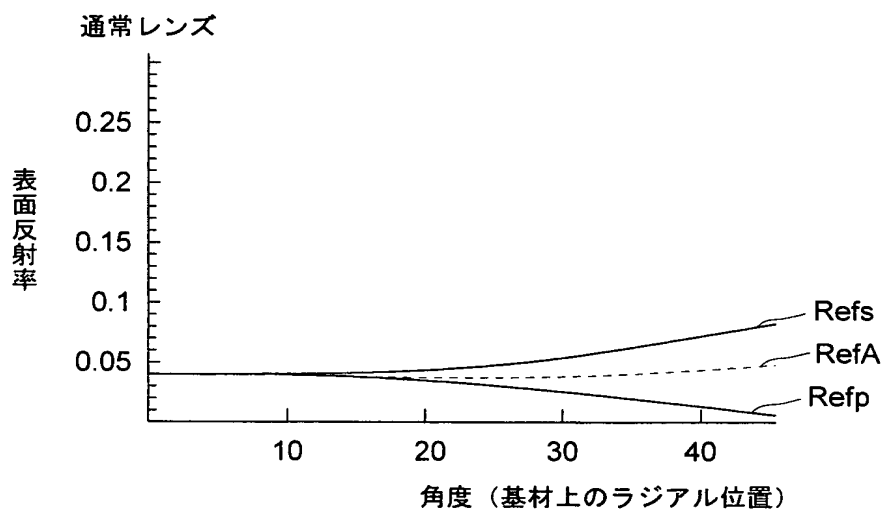


図 20

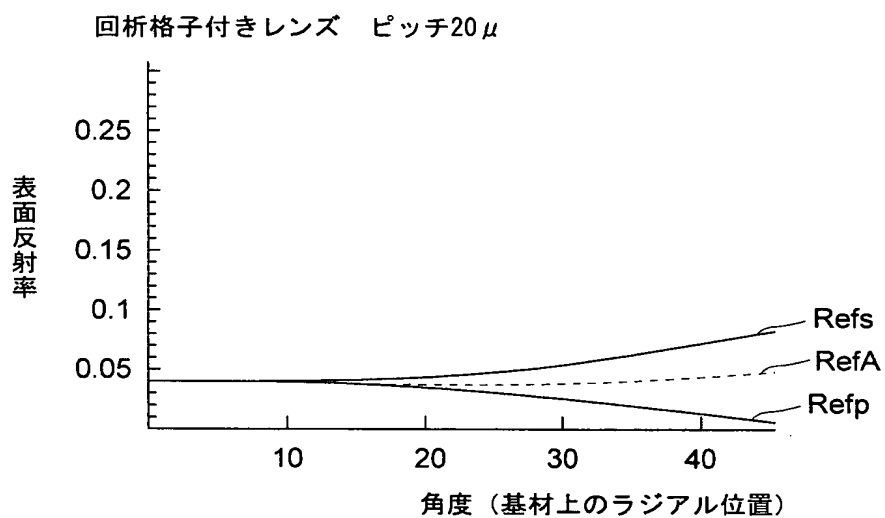


図 21

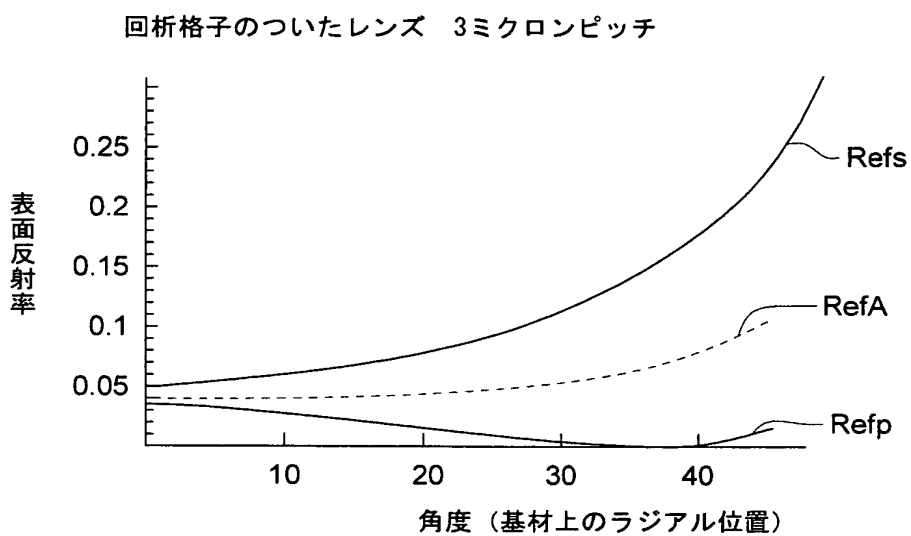


図 22

反射防止構造を設けた 回析格子 (3 μ)に反射防止構造のついたレンズ
非クラスター部 面積比 70%

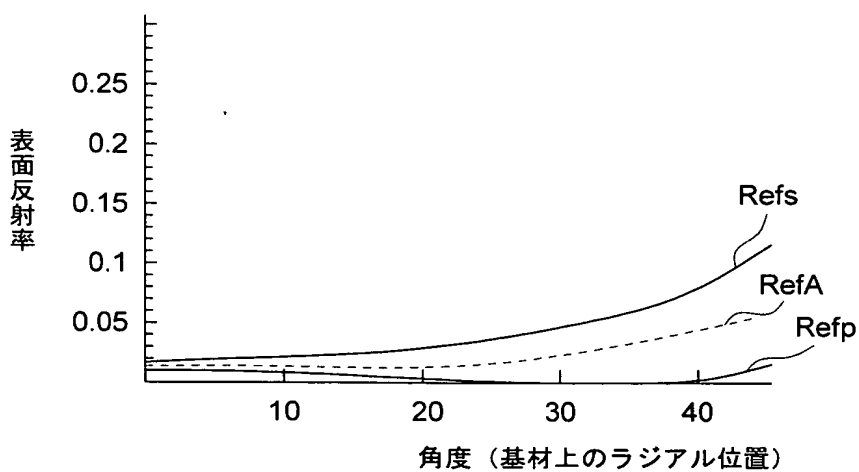


図 23

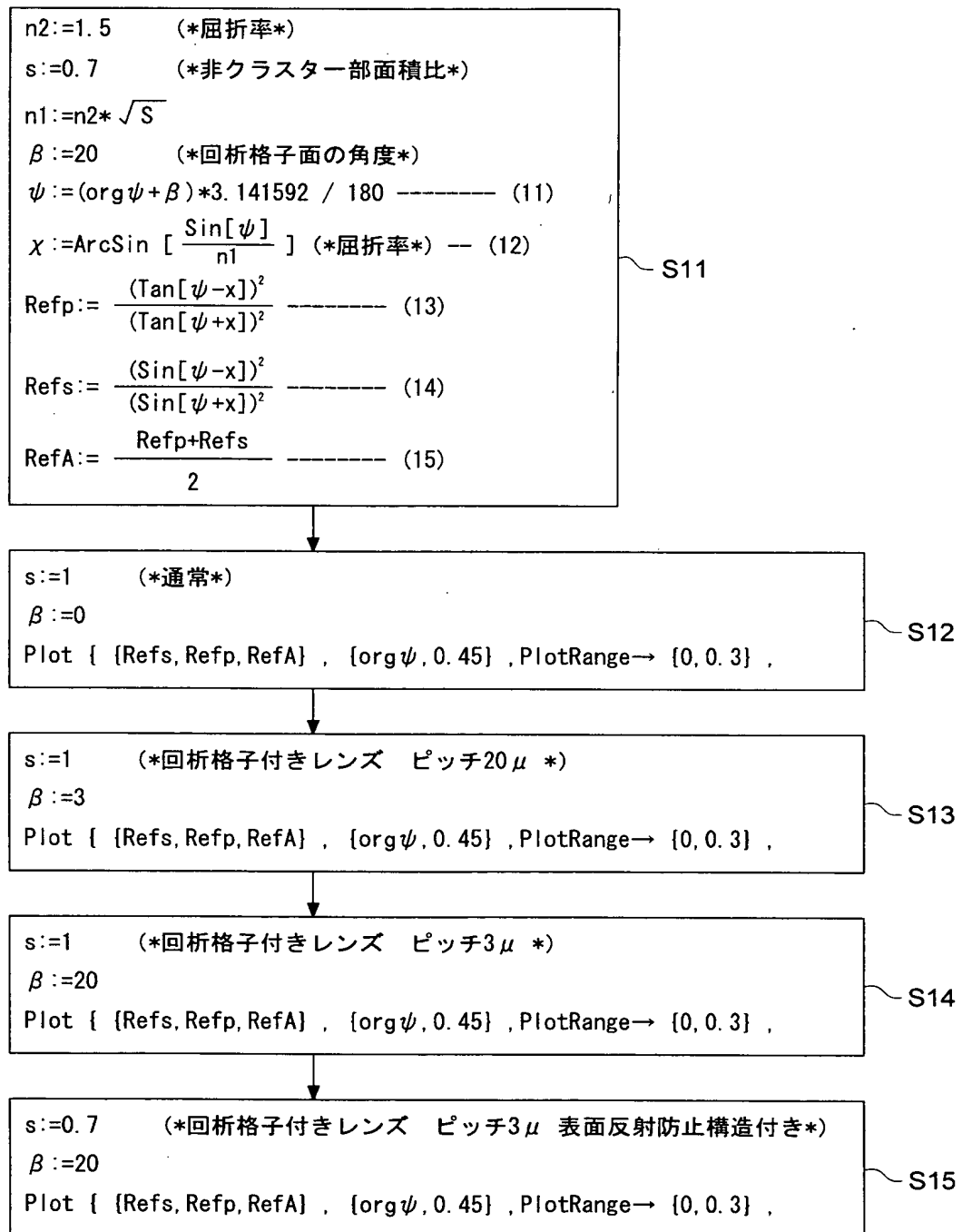


図 24

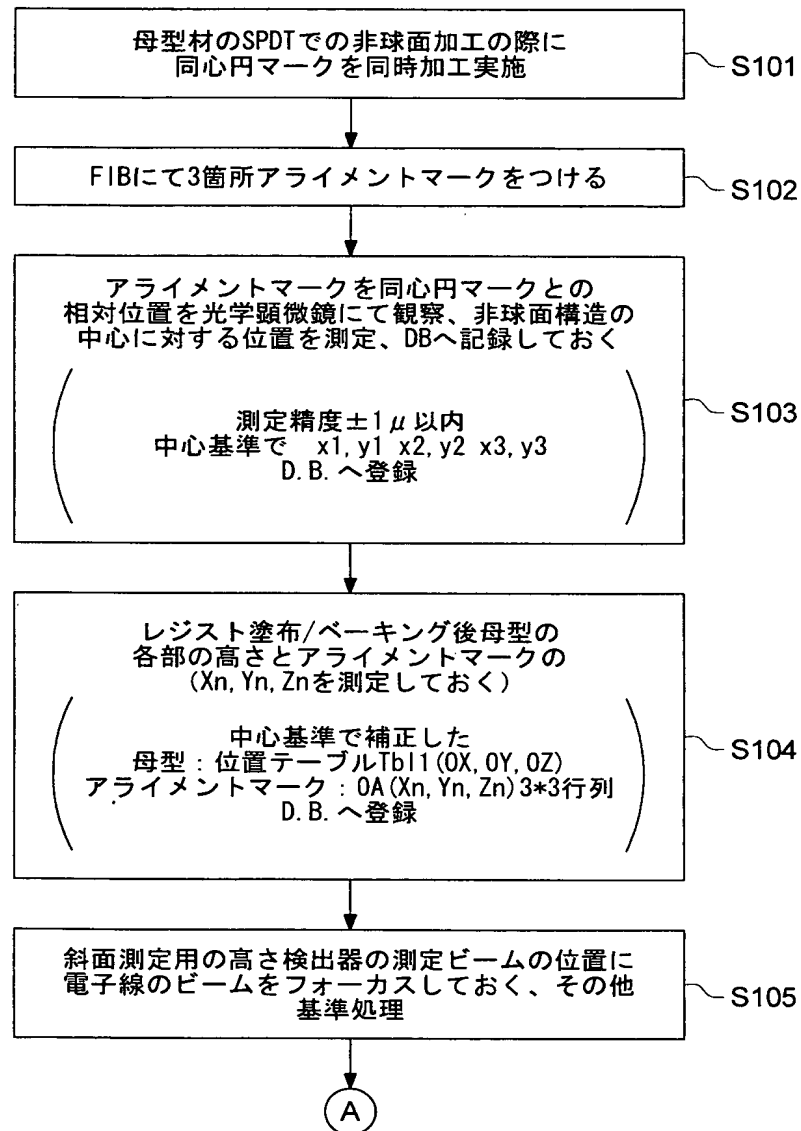


図 26

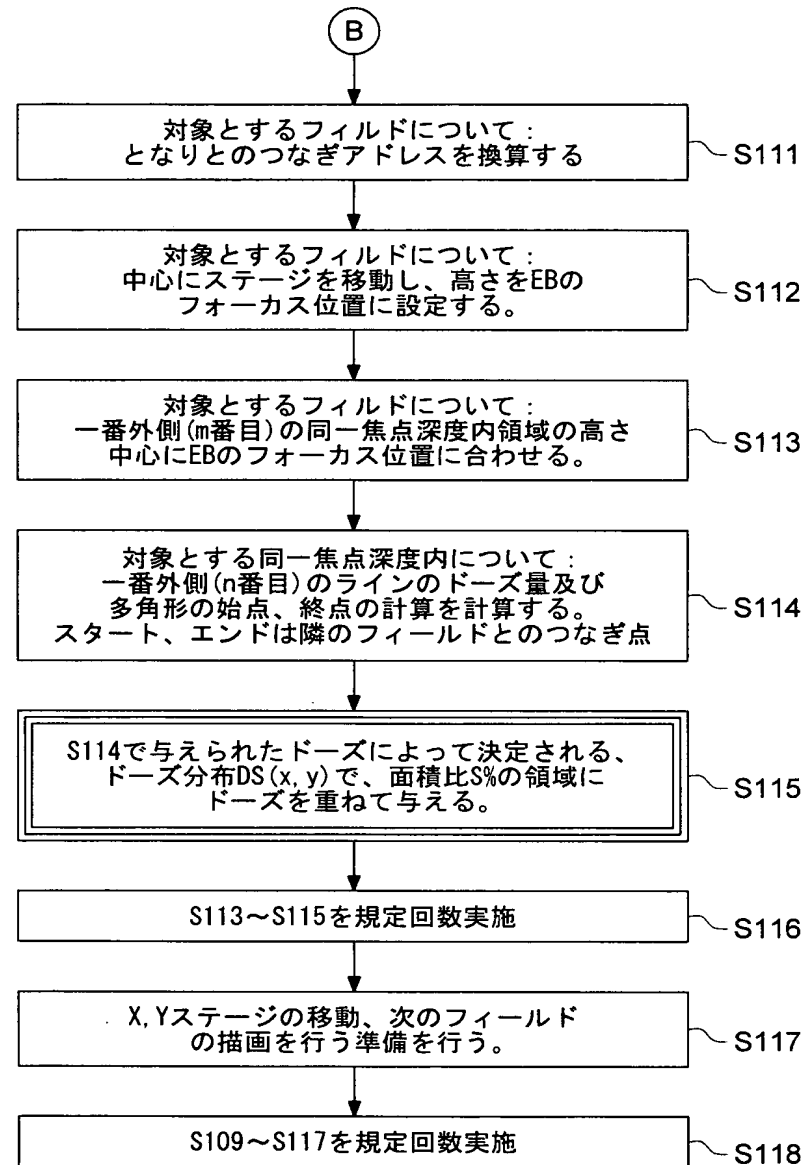


図 27 (A)

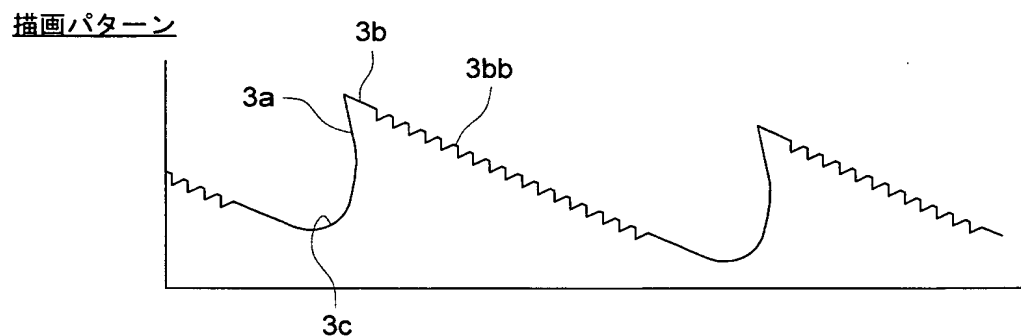


図 27 (B)

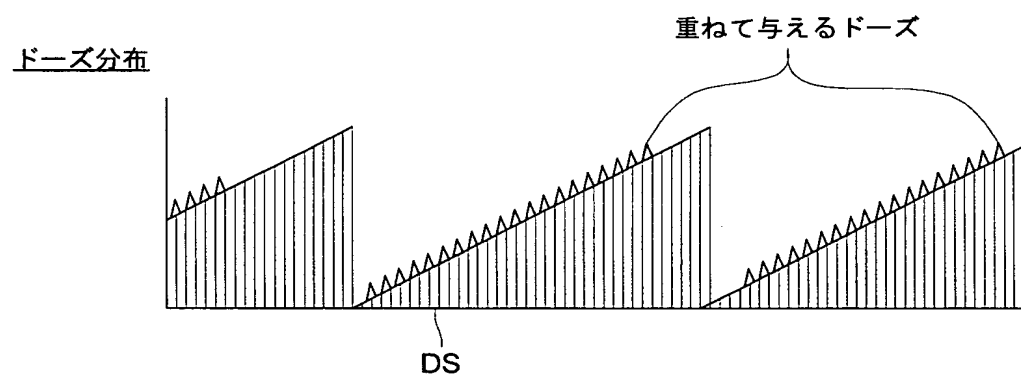


図 28 (A)

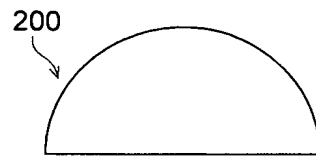


図 28 (B)

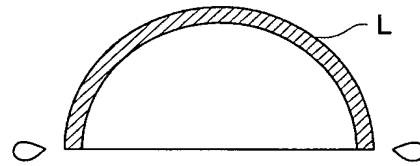


図 28 (C)

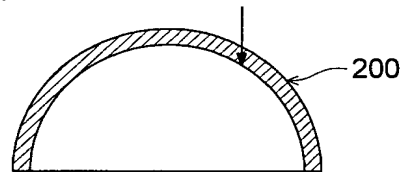


図 28 (D)

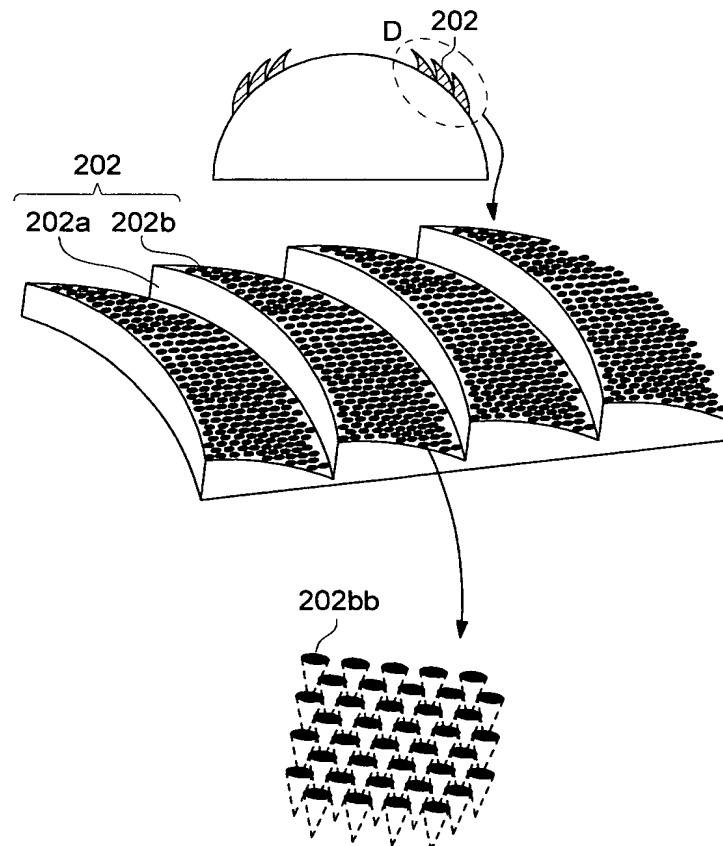


図 29 (A)

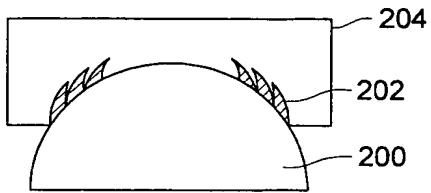


図 29 (B)

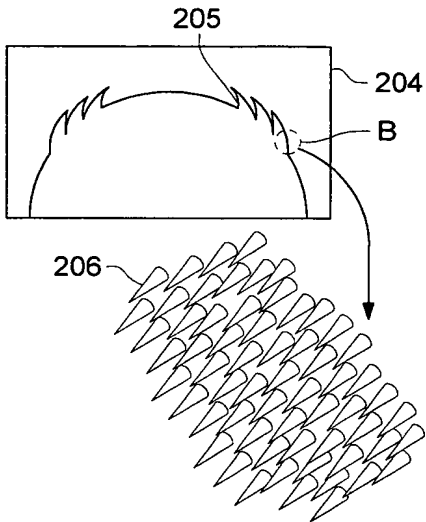


図 29 (c)

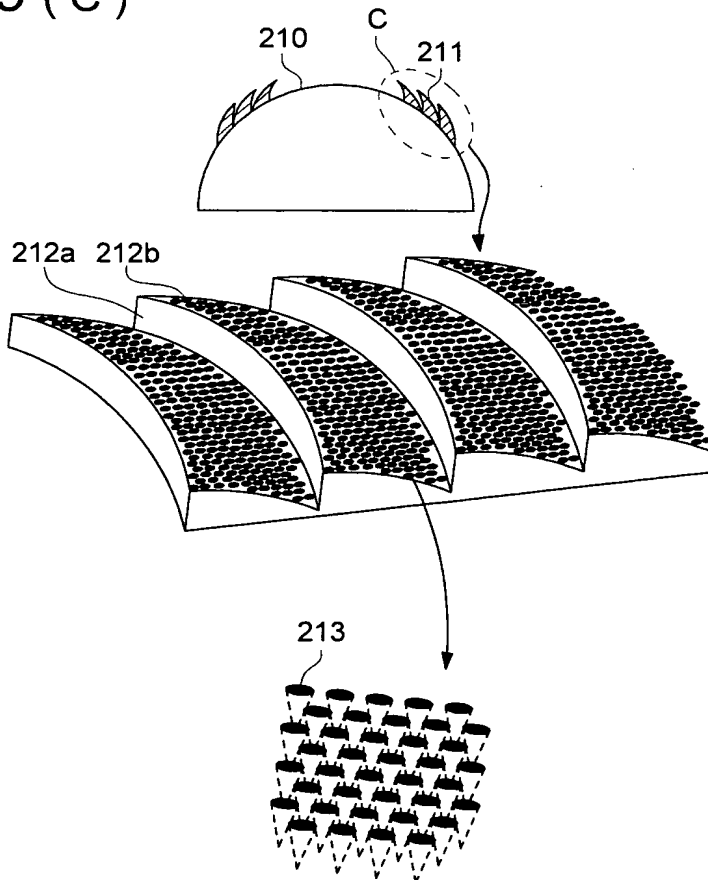


図 30

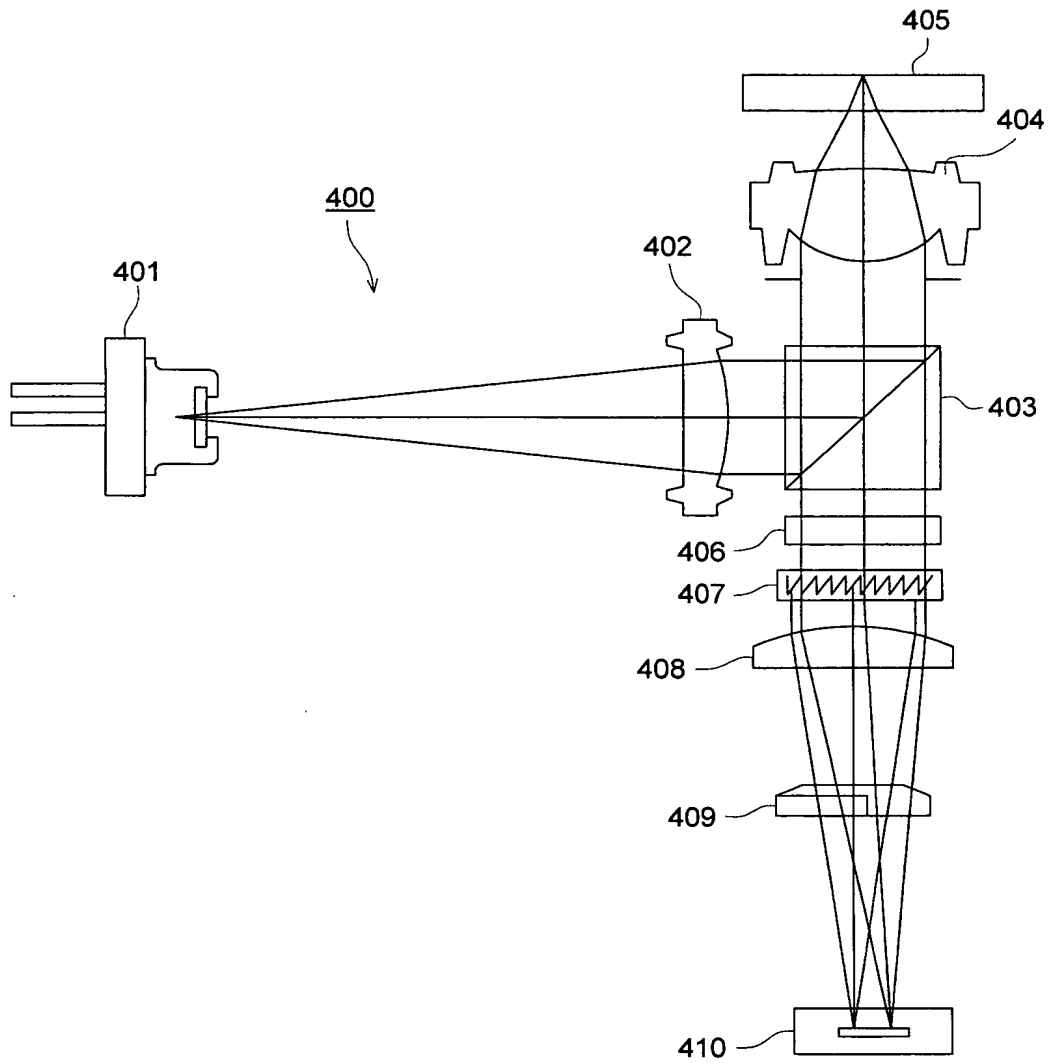


图 3-1

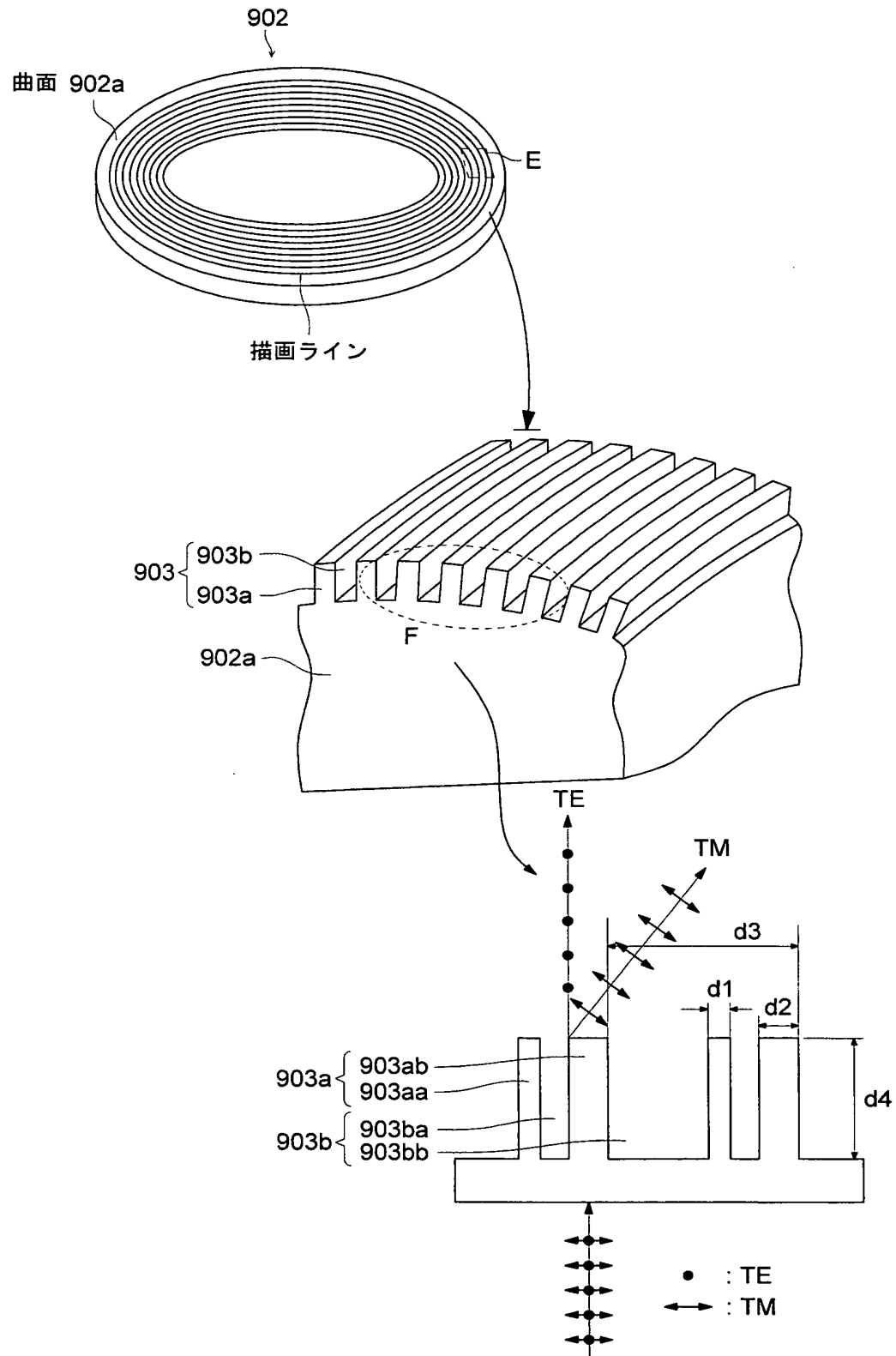
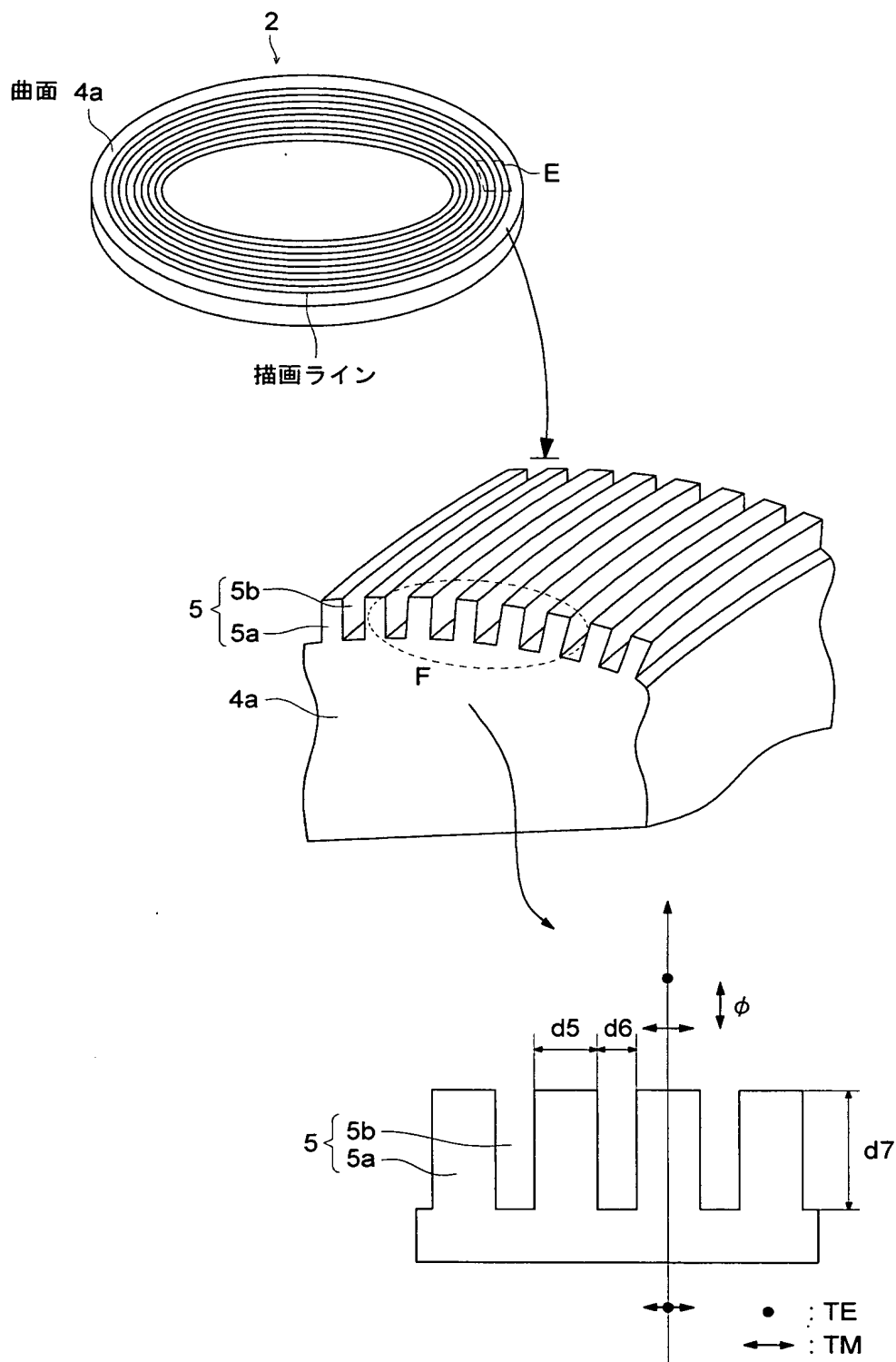


図 32



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図 33

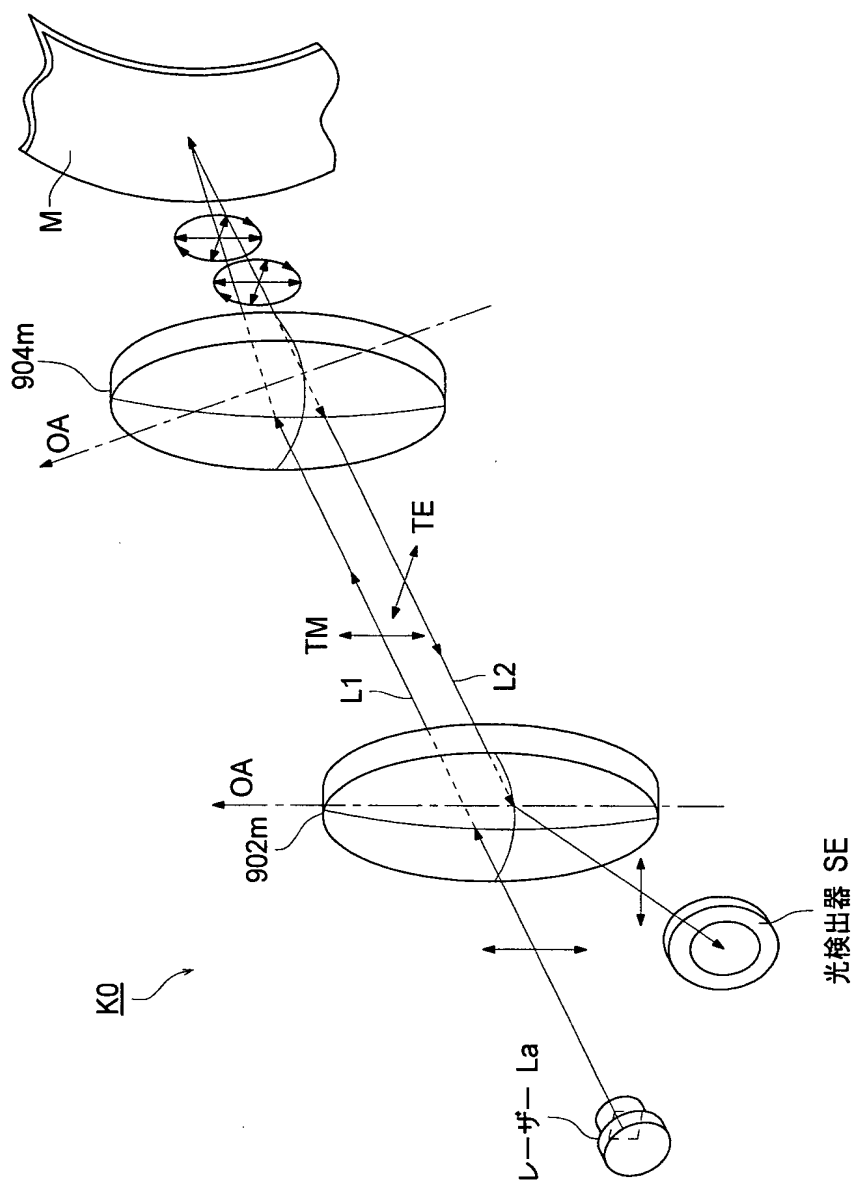


図 34 (A)

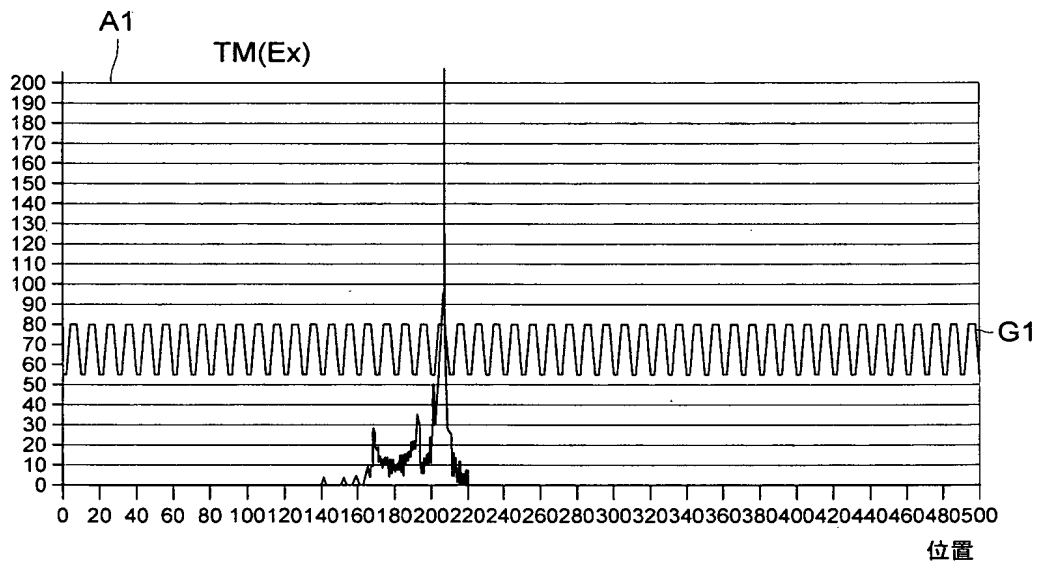


図 34 (B)

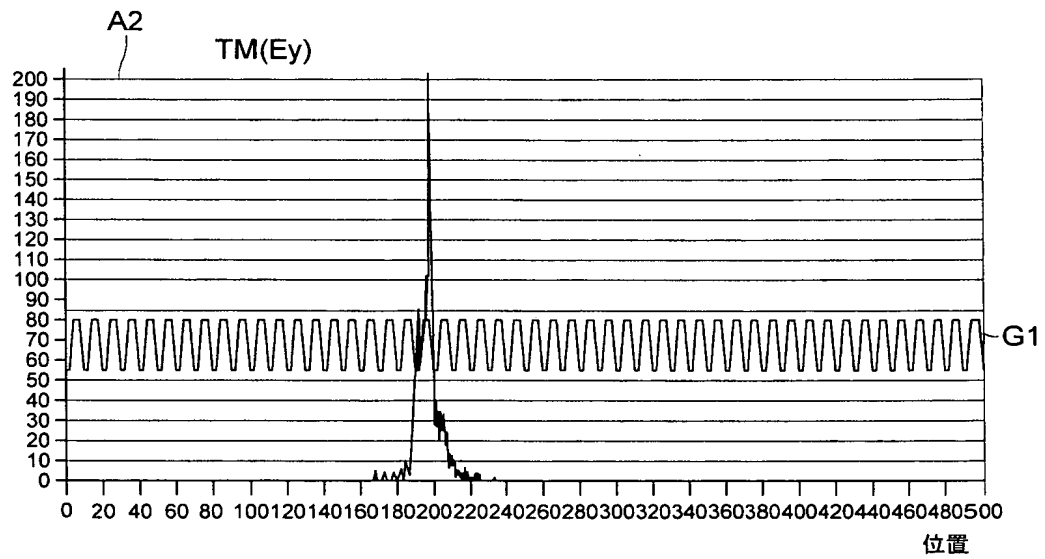


図 35 (A)

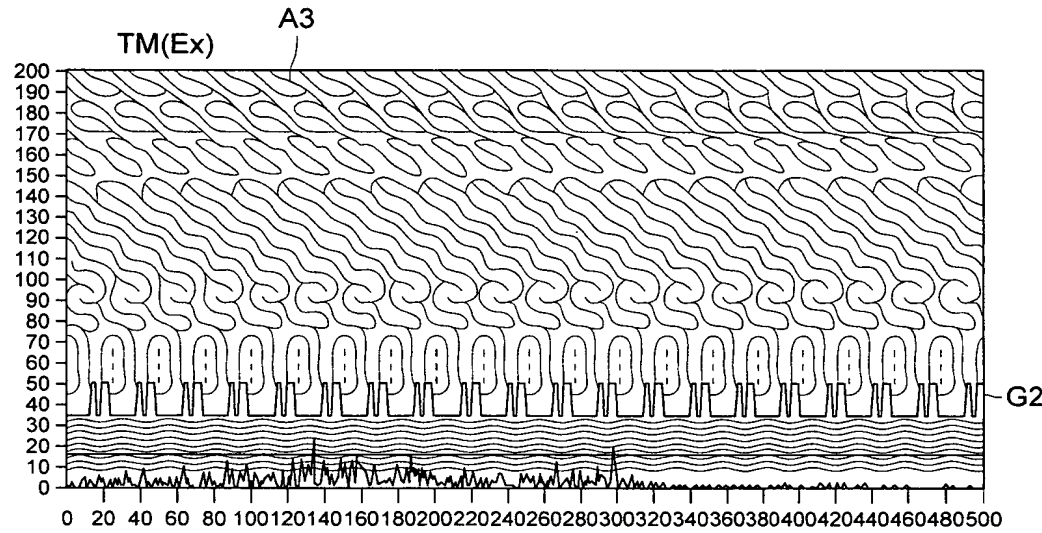


図 35 (B)

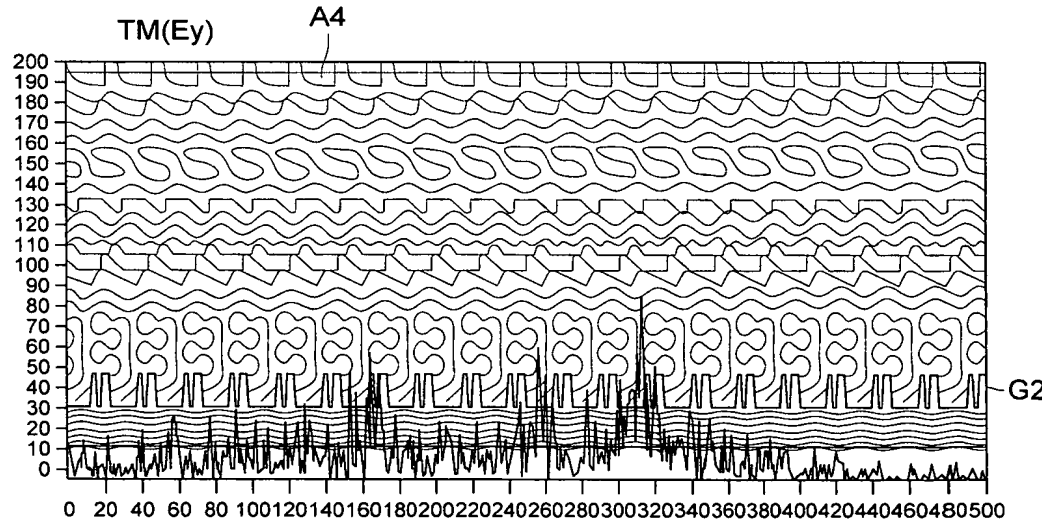
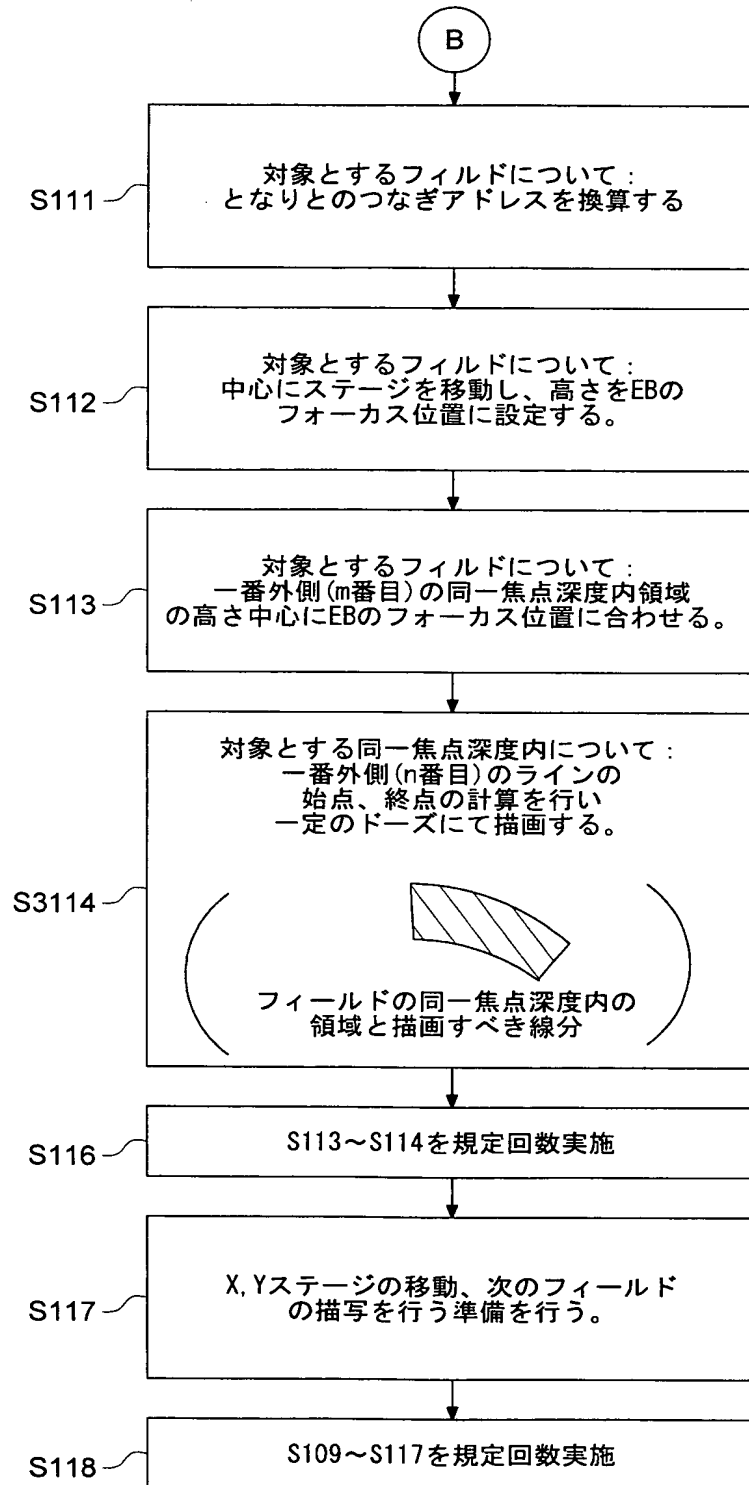


図 36



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図 37 (A)

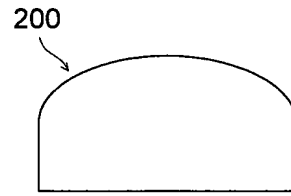


図 37 (B)

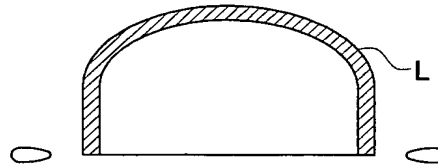


図 37 (C)

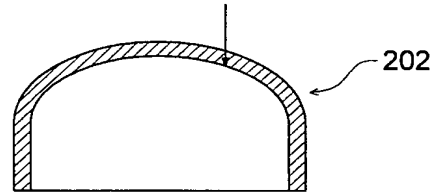


図 37 (D)

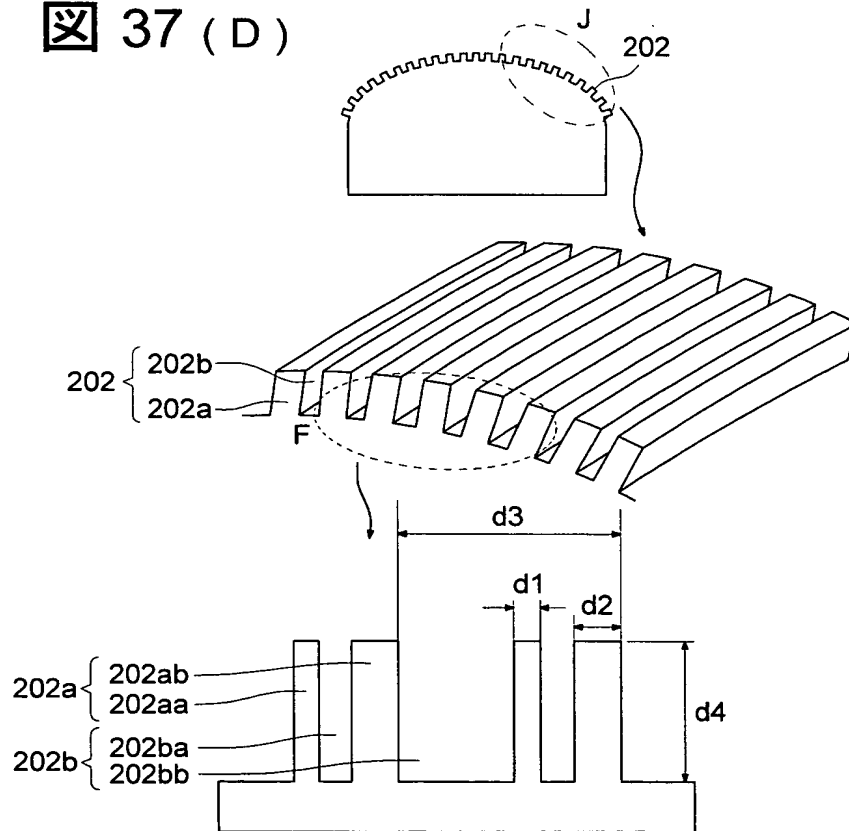


図 38 (A)

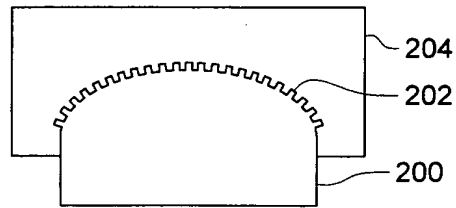


図 38 (B)

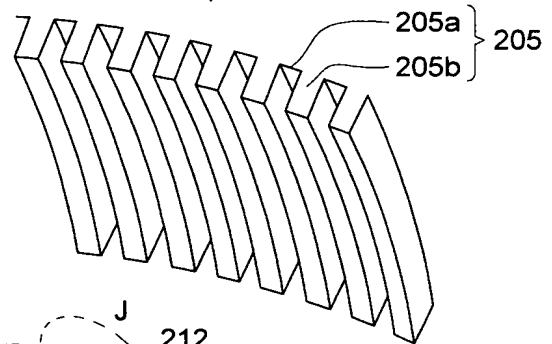
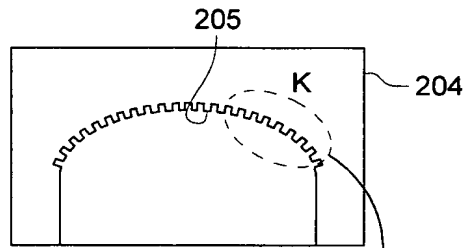


図 38 (C)

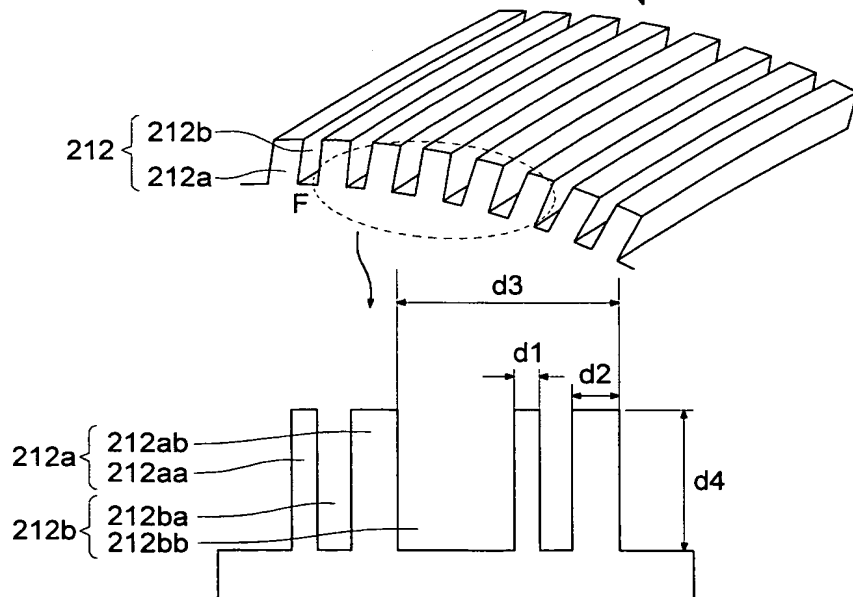
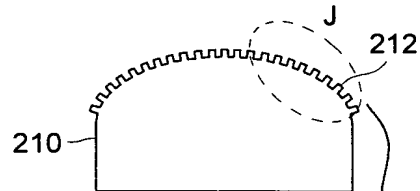


図 39 (A)

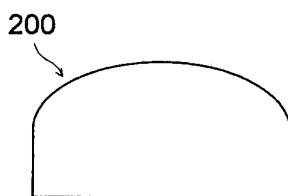


図 39 (B)

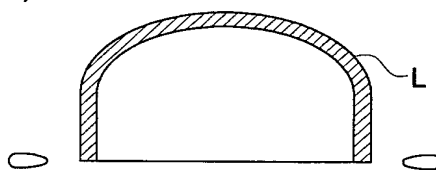


図 39 (C)

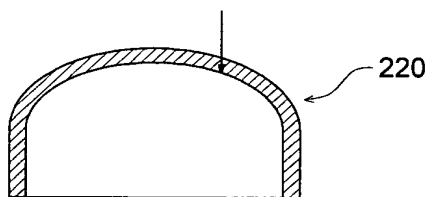


図 39 (D)

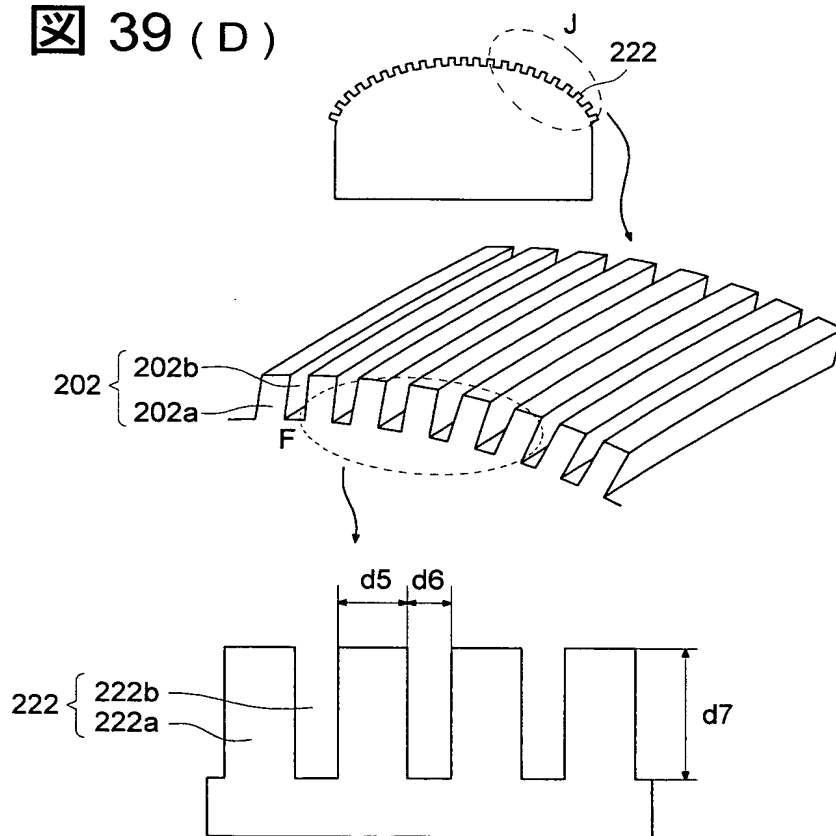


図 40 (A)

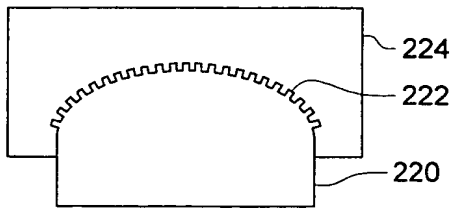


図 38 (B)

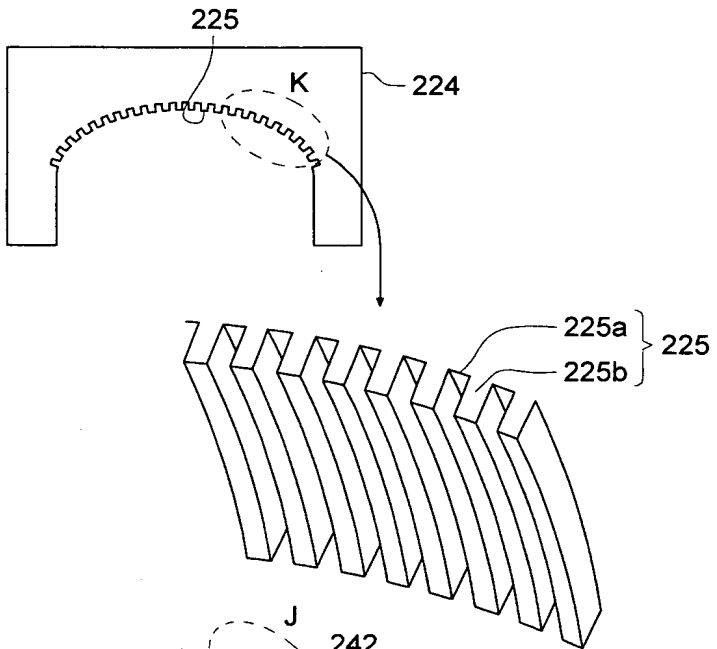


図 40 (C)

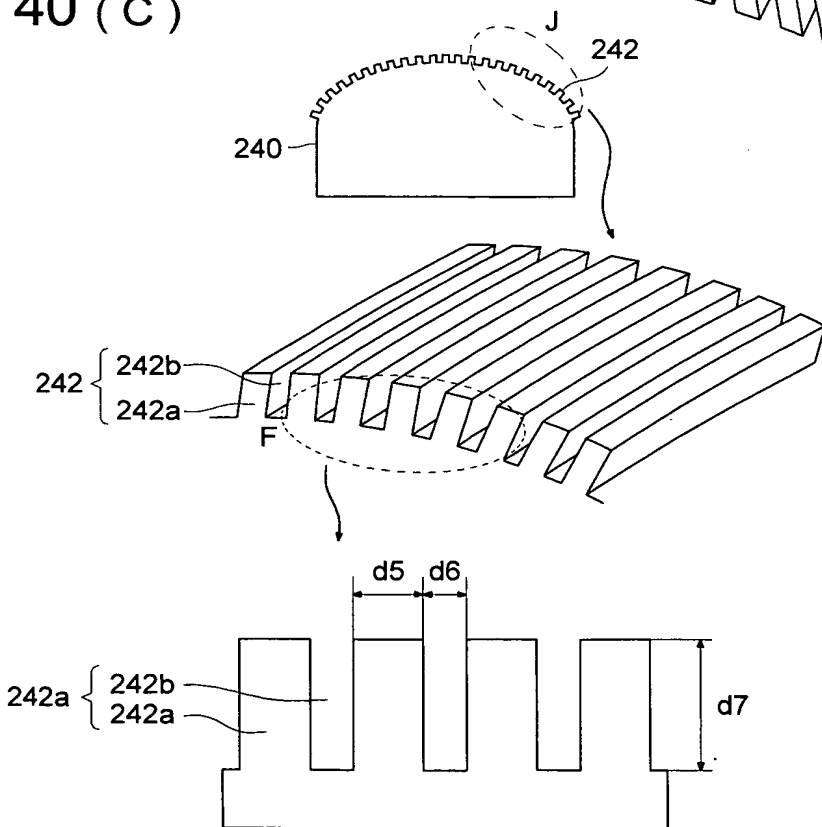


図 41

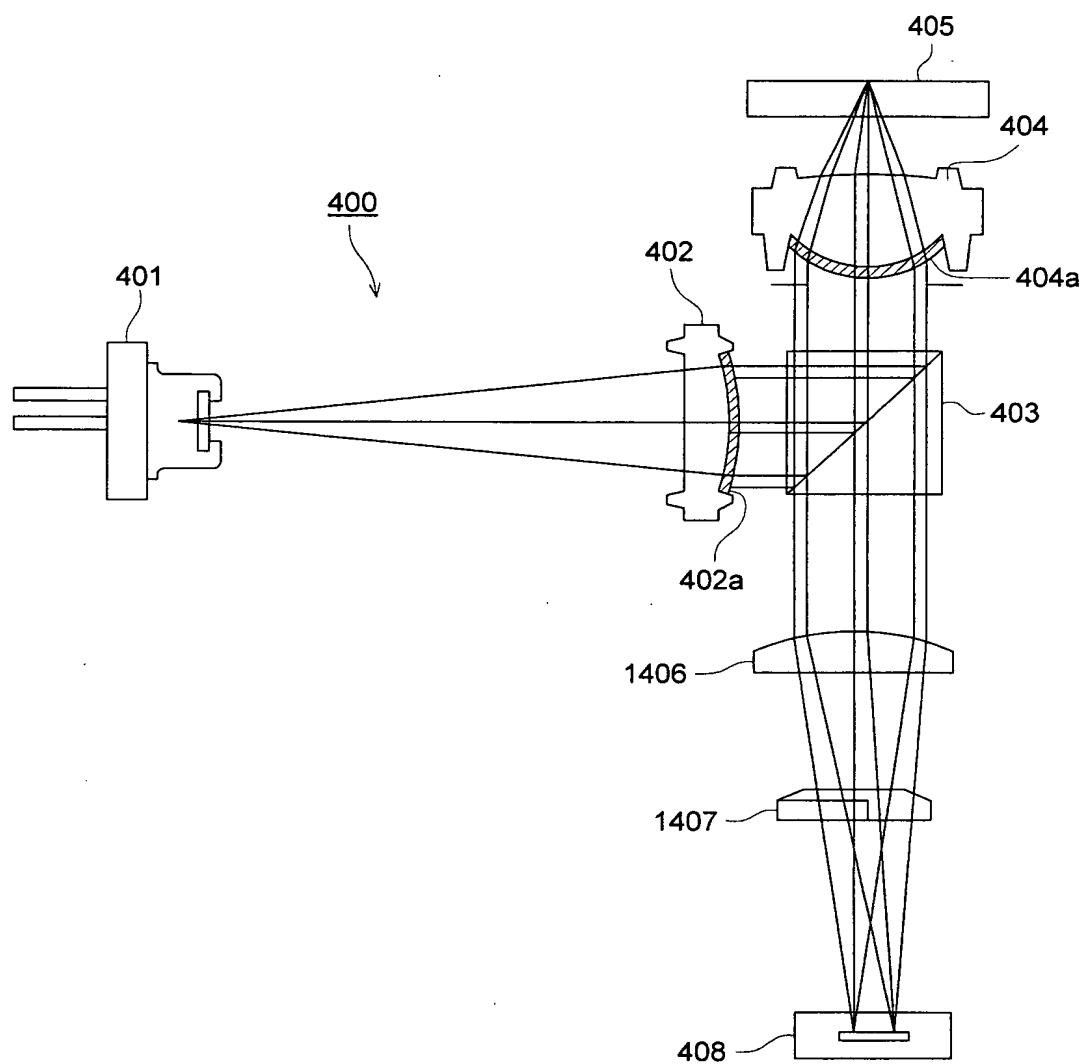


図 42

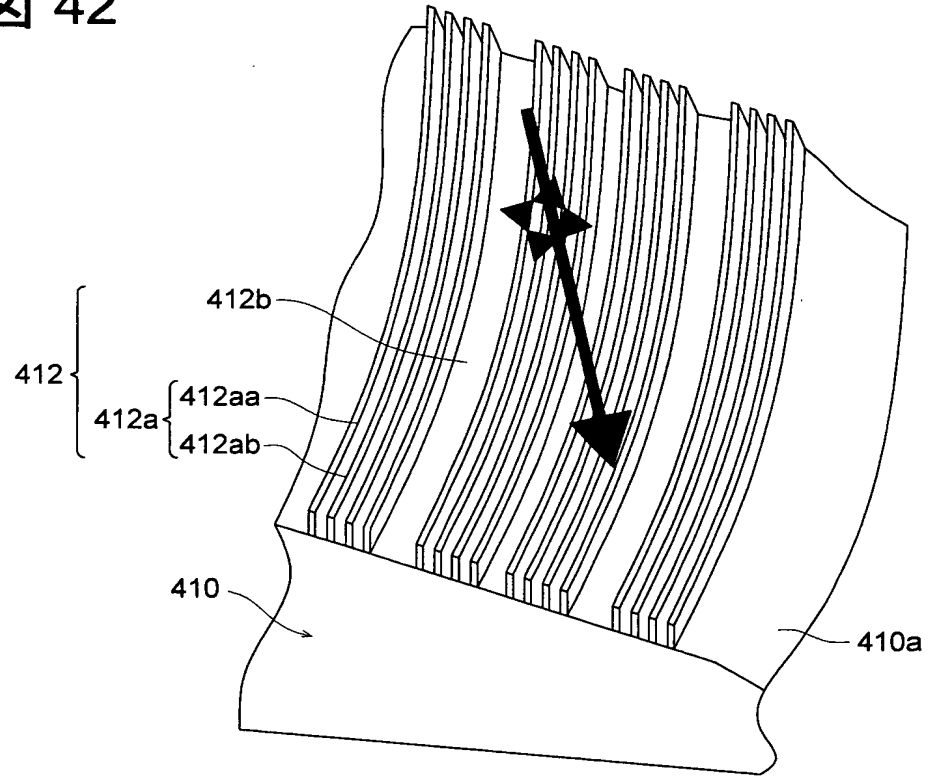


図 43

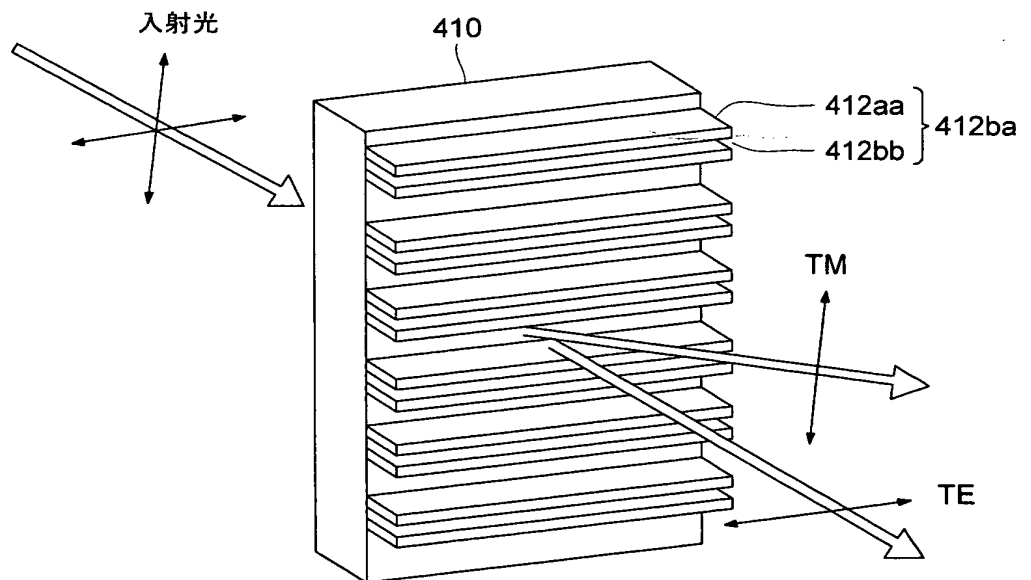


図 44

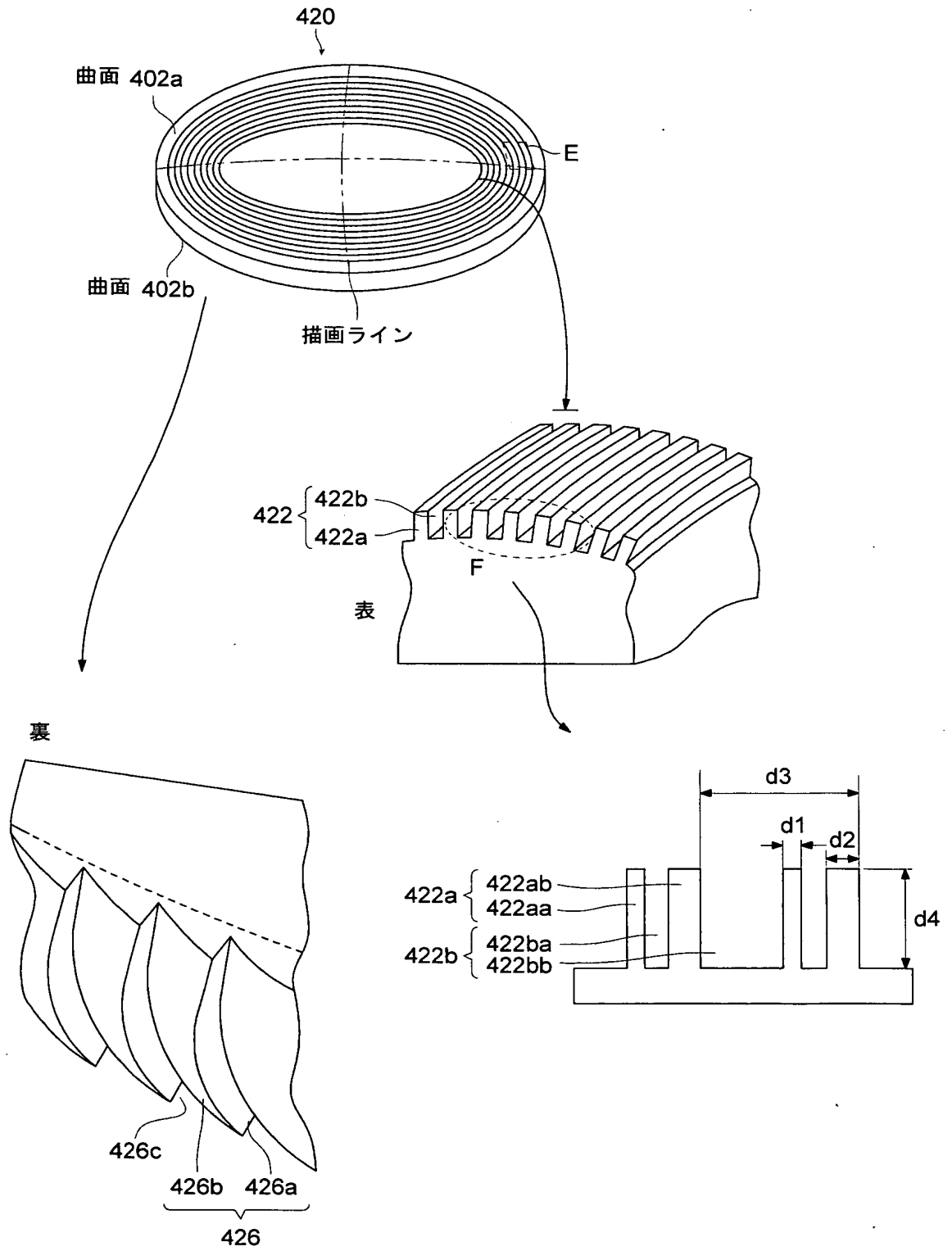


図 45 (A)

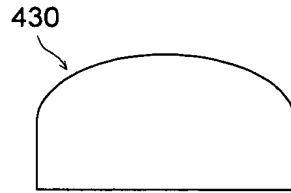


図 45 (B)

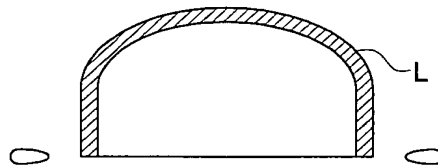


図 45 (C)

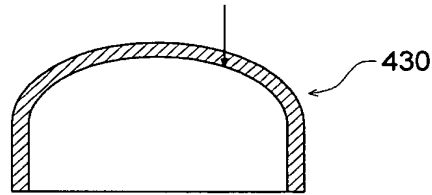


図 45 (D)

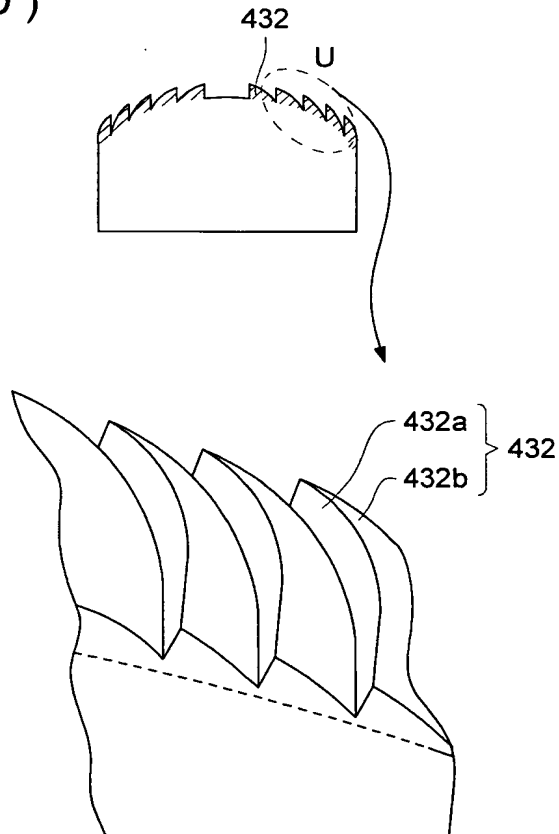


図 46 (A)

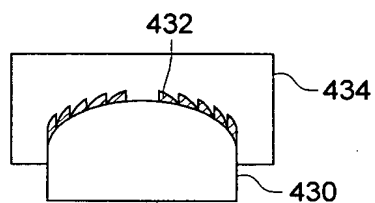


図 46 (B)

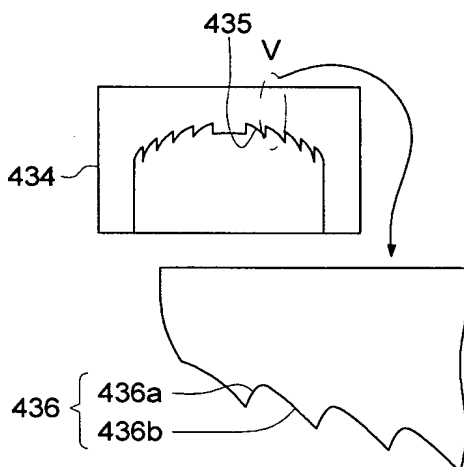


図 46 (C)

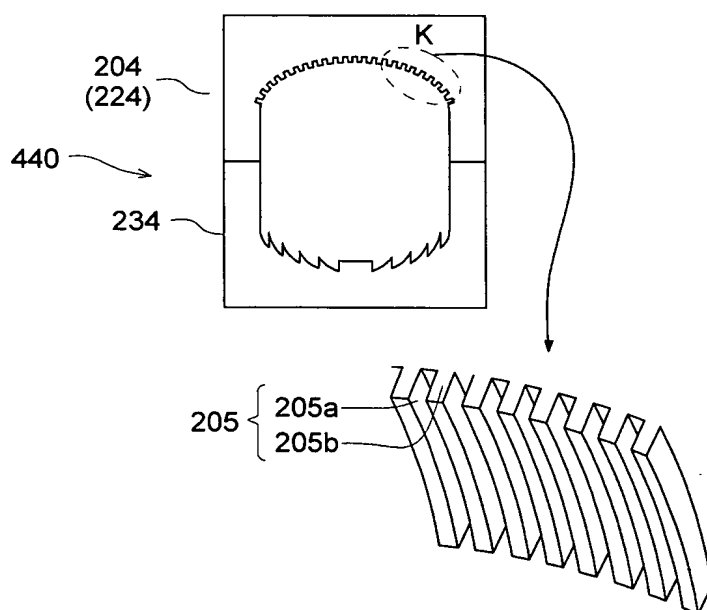
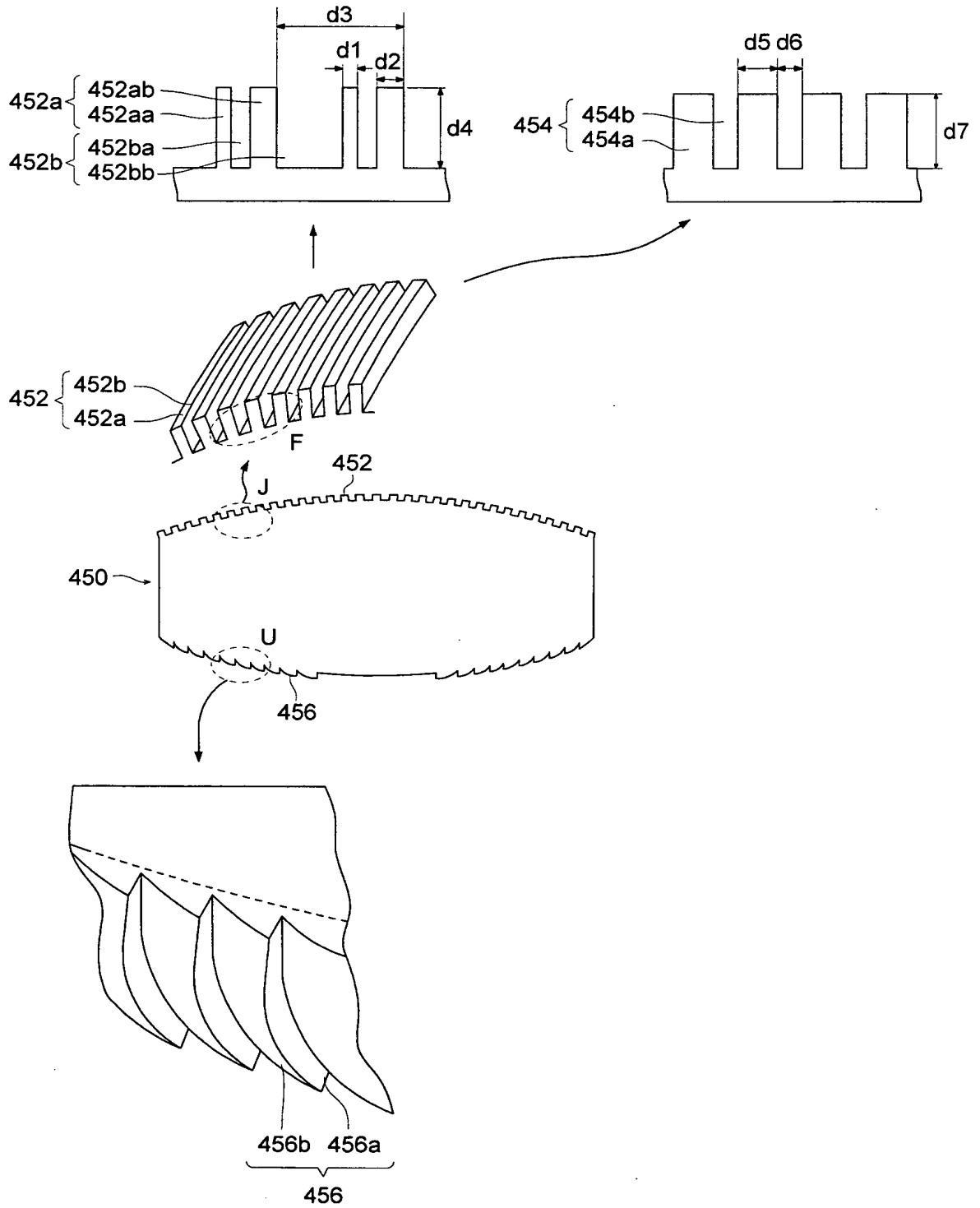
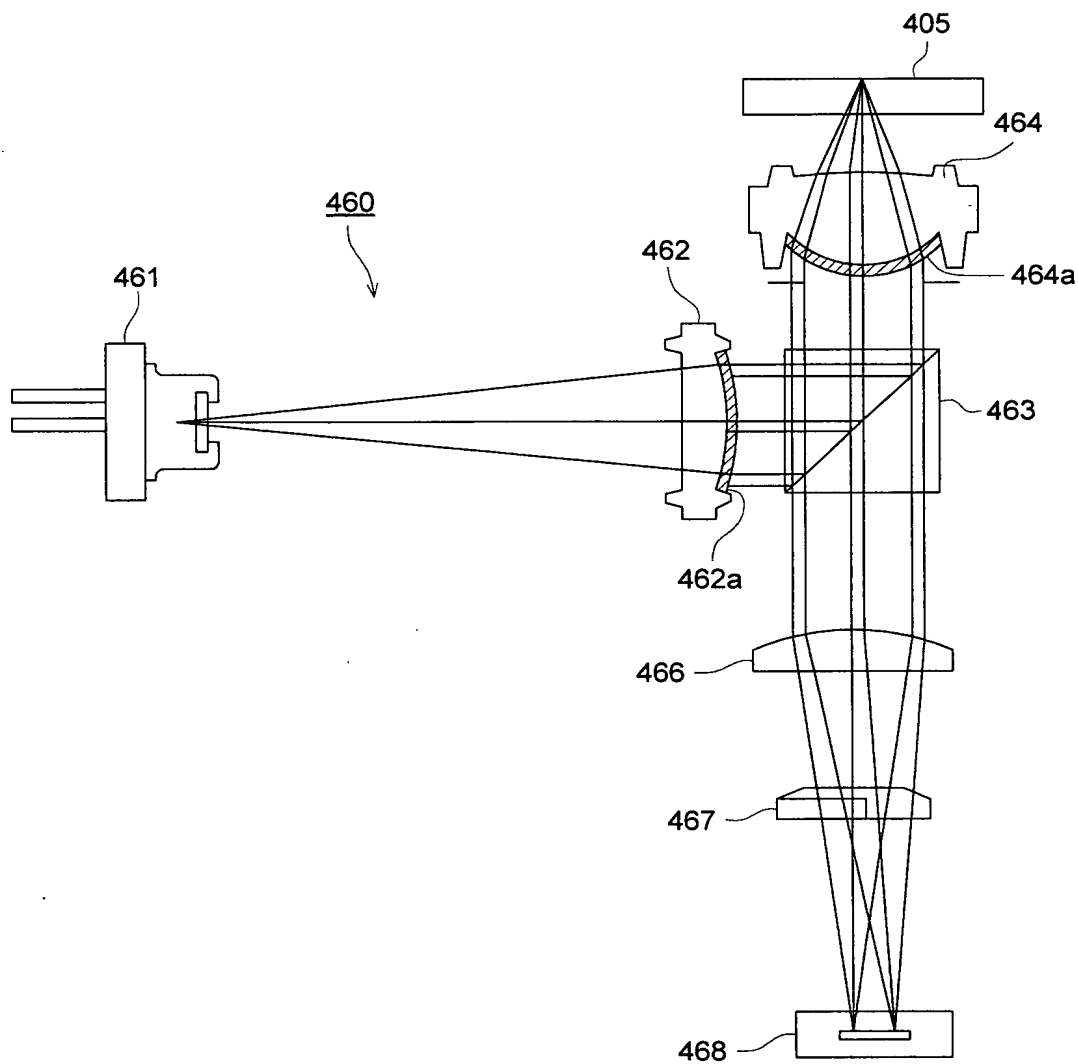


図 47



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図 48



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